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SCANNING PROBE INVESTIGATIONS OF NANOPATTERNED AND THERMO-RESPONSIVE POLYPEPTOIDS AND THE DESIGN OF A SAMPLE STAGE FOR FORCE MODULATION MICROSCOPY

A Dissertation

Submitted to the Graduate Faculty of the Louisiana State University and Agricultural and Mechanical College in partial fulfillment of the requirements for the degree of Doctor of Philosophy

in

The Department of Chemistry

by Lu Lu B.S., University of Science and Technology of China, 2010 August 2015

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LIST OF ABBREVIATIONS

ABBREVIATION	NAME			
AFM	Atomic force microscopy			
OTS	Octadecyltrichlorosilane			
APTES	(3-Aminopropyl)triethoxysilane			
P(NEG ₃₂ - <i>r</i> -NBG ₁₇)	Poly[(<i>N</i> -ethyl glycine) ₃₂ - <i>r</i> -(<i>N</i> -butyl glycine) ₁₇]			
UTS	10-Undecenyltrichlorosilane			
FMM	Force modulation microscopy			
FM-AFM	Force modulation atomic force microscopy			
CMPS	4-(Chloromethyl)phenyltrichlorosilane			
IMM	Indirect magnetic modulation			
ТММН	1,1,1-Tris(mercaptomethyl)heptadecane			
SAMs	Self-assembled monolayers			
Allyl-NCA	N-allyl N-carboxyanhydride			
PBLG	Poly (γ-benzyl- <i>L</i> -glutamate)			
PMLG	Poly(y-methyl <i>L</i> -glutamate)			
PLGA	Poly(<i>L</i> -glutamic acid)			
PLL	Poly(<i>L</i> -lysine)			
PEG-silane	2-[Methoxy(polyethyleneoxy)propyl] trichlorosilane			
CD	Circular dichroism			
SI-ATRP	Surface-initiated atom transfer radical polymerization			
PNIPAAm	Poly(<i>N</i> -isopropyl acrylamide)			

LCST	Lower critical solution temperature		
CuAAC	Copper (I) catalyzed azide-alkyne cycloaddition		
LB	Langmuir-Blodgett		
FOETS	(Perfluorooctyl)ethyl]trichlorosilane		
DMPC	Dimyristoylphosphatidylcholine		
QP	Quercetin palmitate		
OTE	Octadecyltriethoxysilane		
DPDA	Diamino-diethyl-ene glycol-pentacosadiynoic acid		
PS	Polystyrene		
PVME	Poly(vinyl methyl ether)		
PP	Polypropylene		
EP	Ethylene propylene		
PEO	Polyethyleneoxide		
PDMS	Poly(dimethylsiloxane)		
P2VP	Poly-2-vinylpyridin		
PtBMA	Polytertbutylmethacrylate		
c-PNMG ₁₀₀ -b-PNDG ₁₀	Poly(<i>N</i> -methyl glycine) ₁₀₀ - <i>b</i> -poly(<i>N</i> -decyl glycine) ₁₀		
SPM	Scanning probe microscopy		

ABSTRACT

Protocols for patterning nanostructures of polymers were developed to enable scanning probe microscopy (SPM) studies of surface properties at the molecular level. A chemically selective surface for patterning polymers was generated by combining particle lithography with organosilane immersion. Poly(*N*-allyl glycine), a biocompatible and backbone degradable polypeptoid, was grown on Si(111) at confined amine sites using surface-initiated polymerization (also known as the "graft from" approach). A thermo-responsive random copolypeptoid, poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine₁₇)], was pre-synthesized and attached onto a patterned organosilane surface using a thiol-ene click reaction ("graft to" approach). The phase transitions of the copolypeptoid nanostructures in an aqueous environment was studied using *in situ* atomic force microscopy (AFM). A heated stage was used to heat the nanopatterned sample in liquid media.

Force modulation microscopy (FMM), one of over 50 possible modes of SPM, is used to acquire mechanical properties of samples concurrent with topographic information. The history, instrument set-up, advantages, and applications with self-assembled monolayers, polymers, biological and inorganic samples are reviewed in this dissertation. The sample is placed directly on an xyz scanner for the most common FMM configuration. Most commercial SPM systems are designed to have the tip mounted on the piezotube scanner. To facilitate FMM with tip-mounted scanners, a sample stage was designed and constructed of machined polycarbonate. A piezoactuator in the sample stage was used to drive the vibration of the sample in the z-direction at selected frequency and amplitude. The sample stage was evaluated by studying three samples with increasing complexity. This sample-driven FMM was compared with indirect magnetic modulation (IMM), an alternate way to accomplish force modulation studies by modulating the nosecone assembly. A test platform of patterned nanoring samples was evaluated to systematically

compare FMM and IMM. Both methods can be used to sensitively acquire high resolution images of sample elasticity. However, the newly designed sample stage for FMM is easier to operate compared with IMM.

CHAPTER 1. INTRODUCTION

Protocols have been developed in this dissertation for studies of polymerization reaction mechanisms at the molecular level using a surface test platform of patterned polymer nanopillars. Several imaging modes of atomic force microscopy (AFM) were selected or developed to investigate systems of interest. A prototype sample stage accessory for AFM was designed and evaluated to enable advanced measurements with force modulation microscopy.

1.1 Nanoscale Surface Studies with Atomic Force Microscopy

Since the invention of AFM in 1986,¹ new studies have been advanced for surface analysis in fields such as biology,²⁻⁴ polymers,⁵⁻⁷ molecular electronics⁸ and medical diagnostics.⁹⁻¹⁰ The resolution of AFM imaging is not limited by the wavelength of light. With an ultra-sharp probe, the topographic resolution of AFM can achieve 0.1 nm for the x and y directions and 0.01 nm for the z direction.¹¹⁻¹³ More than 50 AFM modes have been developed for imaging and for measuring forces. The background and imaging principle of scanning probe microscopy and the AFM modes used for this dissertation are summarized in Chapter 2, including contact-mode, lateral force imaging, tapping-mode, phase imaging, force modulation microscopy, and indirect magnetic modulation. Characterizations using AFM force spectroscopy and *in situ* temperature studies with a heating stage will also be described.

1.2 Surface Patterning of Polypeptoids Using Particle Lithography

Arrays of polymer nanostructures were prepared on Si(111) using a stepwise chemistry route combined with particle lithography. In the first step, nanopores were prepared within a thin film of a self-assembled monolayer of octadecyltrichlorosilane (OTS). The film of OTS served as a surface resist and the areas of nanopores provided sites for further reactions. The initiator, (3-aminopropyl)triethoxysilane (APTES) was grown selectively inside the nanopores to define surface sites for polymerization reaction to proceed. Surface-initiated ring-opening polymerization

of *N*-allyl *N*-carboxyanhydride with APTES formed polymer pillars on the nanopatterns of APTES, which terminated with amine functional groups. The surface changes for each step were monitored using AFM. Slight variations in the height of the poly(*N*-allyl glycine) pillars were observed which scale correspondingly to the initial dimensions of nanopores. The distance between polymer nanopillars is controlled by the size of mesoparticle masks. This platform has potential application in biotechnology as smart coatings, biosensors or bioseparations based on the biocompatibility, backbone biodegradability and processability of poly(*N*-allyl glycine). In Chapter 3, the strategy of surface patterning of polypeptoids at the nanoscale and the surface characterizations of each step will be presented.

1.3 In Situ Studies of the Thermo-Responsiveness of Polypeptoid Nanopillars

Nanoscale surface test platforms were used to investigate the phase transitions of thermoresponsive copolymer nanostructures with AFM. A clear aqueous solution of the random copolymer poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine)₁₇], abbreviated as P(NEG₃₂-*r*-NBG₁₇), becomes turbid upon heating, and upon cooling returns to a clear appearance. The clarity of the P(NEG₃₂-*r*-NBG₁₇) solution indicates a response to temperature that is attributable to reversible polymeric phase transitions. For studies with AFM, nanopores on Si(111) within a film of octadecyltrichlorosilane (OTS) were prepared using particle lithography combined with steps of solution immersion. A second silane, 10-undecenyltrichlorosilane (UTS), was backfilled into the exposed nanopores to form ultra-small surface reactive sites for site-selective polymer deposition and growth. The random copolymer P(NEG₃₂-*r*-NBG₁₇) was anchored to reactive sites of UTS nanodots to produce patterned polymer pillars. The morphology and surface arrangement of polymer nanopillars were characterized at each step using high resolution AFM. Studies of thermoresponsive properties were developed to accomplish dynamic protocols in liquid media. A temperature stage was used to heat the sample during time-lapse AFM imaging. To the best of our knowledge this is the first report using scanning probe studies to characterize the thermoresponsive properties of patterned polymer pillars as detailed in Chapter 4. Significant advantages are gained by localizing and patterning polymer pillars on surfaces to enable direct visualization of surface changes via AFM studies of thermo-responsive properties.

1.4 Review of Previous Studies with Force Modulation Microscopy

A review of force modulation microscopy (FMM) and the capabilities for nanomechanical mapping of surface elastic and viscoelastic properties is presented in Chapter 5. Force modulation microscopy was invented in 1991 by Maivald and Hansma et al.¹⁴ With FMM, local mechanical properties of a sample can be acquired along with topographic information. Vibration is applied to the z axis at the tip-sample contact during contact-mode imaging. A contemporary review of instrumental configurations for FMM and applications with self-assembled monolayers, polymers, inorganic materials and biological samples is presented.

1.5 A Force Modulation Sample Stage for Scan-by-Tip AFM

Among the modes of scanning probe microscopy that have been developed, FMM is commonly used to acquire mechanical properties of samples along with topographic information. The FMM mode is particularly useful for investigations with polymer samples and organic thin films. We have designed and tested a sample stage for FMM constructed of machined polycarbonate. The generic design enables FMM measurements for instrument configurations with a tip-mounted AFM scanner. A piezoactuator is embedded within the sample stage to drive the sample to vibrate in the z-direction according to selected parameters of alternating current. The invention of the sample stage and applications using three samples is presented in Chapter 6.¹⁵

1.6 Stage-Driven Force Modulation Microscopy versus Tip-Driven Indirect Magnetic Modulation

We have designed and tested a sample stage for force modulation microscopy (FMM) that is applicable for AFM instruments that are configured with a tip-mounted scanner configuration. A piezoactuator within the stage is used to precisely modulate the sample for FMM characterizations. Another AFM mode developed for tip-mounted scanners known as indirect magnetic modulation (IMM), was previously reported by our group.¹⁶ For IMM, an AC electromagnetic field is applied to the nosecone tip holder assembly from a solenoid underneath the sample. The entire tip holder assembly is driven to vibrate to produce modulation of the tipsample contact. In Chapter 7, a test platform of 4-(chloromethyl)phenyltrichlorosilane (CMPS) nanoring patterns were prepared with particle lithography combined with heated vapor deposition. The test structures provide a model surface to compare the two AFM imaging modes: FMM and IMM. A series of frequencies were used for FMM and IMM to investigate the frequencydependent properties of the sample. Frequency sweeps at selected regions of the sample were obtained to evaluate the local differences in elastic response for the nanostructures.

1.7 Conclusions and Future Prospectus

Protocols based on particle lithography have been developed to prepare spatial selective surfaces of polypeptoids. The thermo-responsive properties of nanopatterned polypeptoids was studied using dynamic protocols and liquid imaging media. A prototype sample stage was built and tested for force modulation microcopy. In Chapter 8, the main results of this dissertation are presented along with a discussion of future directions.

CHAPTER 2. EXPERIMENTAL DESIGNS WITH SCANNING PROBE MICROSCOPY

Protocols were developed in this dissertation for characterizing nanostructures of organic thin films and polymers using selected modes of scanning probe microscopy (SPM). A key strategy was to create unique surface test platforms of exquisitely uniform nanopatterns or organosilanes and polymers. Several imaging modes were selected or developed for the investigations of this dissertation. A prototype sample stage for force modulation microscopy (FMM) was designed and evaluated to enable advanced measurements with tip-mounted AFM scanner configurations.

2.1 Background and Imaging Principle of Atomic Force Microscopy

Atomic force microscopy (AFM) was invented in 1986 by Binnig, Quate, and Gerber and has become a powerful tool for surface analysis.¹ New capabilities for acquiring surface morphology with molecular and atomic resolution can be routinely achieved with AFM when using a sharp probe. By monitoring the interactions between the probe and samples, surfaces properties such as friction, viscoelasticity, conductivity, and magnetism can be recorded with digital images.¹⁷⁻²⁰

An advantage of AFM is that the images can be acquired in air, vacuum and liquid environments, which enables dynamic studies of *in situ* time-lapse reactions.²¹⁻²² Samples for AFM characterization do not need to be coated with a conductive metal layer for imaging in vacuum as with electron microscopy. The sample must be relatively flat (usually z scale less than 1 μ m for best resolution) to be suitable for AFM studies. Diverse samples can be characterized with AFM, such as self-assembled monolayers,²³⁻²⁴ polymers,²⁵⁻²⁶ nanoparticles,²⁷⁻²⁸ proteins,²⁹⁻³⁰ cells,³¹⁻³² and DNA.³³⁻³⁴ The resolution achieved with AFM reaches 0.1 nm for the x and y directions using an ultra-sharp probe and 0.01 nm for the z direction.¹¹⁻¹³

Commonly used AFM tips are made of silicon or silicon nitride, which are attached to either a V-shaped or rectangular cantilever. The backside of the cantilevers are coated with reflective materials such as gold. A diode laser is positioned onto the back of a cantilever and reflected to the center of a position-sensitive four-quadrant photodiode detector. Changes of the cantilever deflection and oscillation amplitude are monitored by the photodetector and are maintained at an assigned setpoint through an electronic feedback loop. Images of surfaces are constructed by recording the topography and tip-sample interaction as a function of tip position. A topograph of the sample can be acquired with AFM. Additional information such as frictional, viscoelastic, magnetic and conducting properties can be simultaneously acquired with topographs.

More than 50 AFM modes have been developed during the past 30 years and the imaging modes can be categorized by how the AFM tip is operated relative to the sample: contact, non-contact and intermittent-contact. For contact-mode AFM, the tip is placed in continuous contact with surface. For non-contact-mode, the tip is maintained at a discrete distance from the sample to measure forces (e.g. electrostatic, van der Waal's, magnetic) within a specific distance from the surface. With intermittent-contact-mode, also known as tapping-mode AFM, the tip is driven to oscillate at or near its resonant frequency and "taps" the surface during scans. Contact-mode and tapping-mode are the most common modes of AFM, and are used in this dissertation. Other modes to be introduced in this Chapter are AFM force spectroscopy, force modulation microscopy, and *in situ* temperature studies using AFM.

2.2 Contact-mode and Lateral Force Imaging

Contact-mode is widely used in the field of surface analysis. The first contact-mode image was published in 1986 when Binnig et al. invented AFM, showing line traces on a ceramic (Al₂O₃) sample.¹ Atomic resolution of a graphite surface was achieved in 1987 by Binnig et al. shortly after the invention of AFM.¹³

During contact-mode imaging, a sharp probe is scanned in a raster pattern across the surface using a piezoelectric scanner (Figure 2.1). The probe is attached to the end of the cantilever

and has a radius of ~10 nm. The deflection changes of the cantilever due to the changes in tipsample interaction are monitored with a photodetector. The force between the tip and sample is maintained at a constant setting by a feedback loop, which can be precisely controlled by applying voltage to the scanner. Changes in cantilever deflection due to sample topography will lead to vertical movement of the laser spot on the photodetector. Changes in torsional twisting of the cantilever due to sample frictional force will influence lateral placement of the laser spot on the photodetector. The photodetector is used to sensitively track the movement of the laser spot and translate the electrical signal to digital AFM images as shown in Figure 2.1.

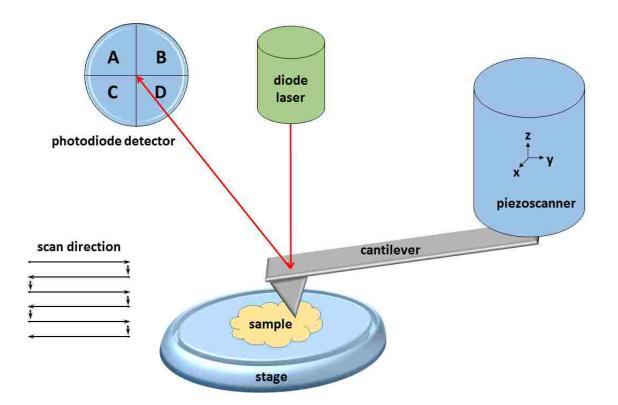


Figure 2.1 Operating principle of contact-mode AFM.

Three types of AFM images can be generated concurrently with contact-mode AFM: topography, deflection and lateral force images. Topography images are height traces of the surface and give a 3D profile of the surface morphology. The topography frames are generated

from plotting the scanner z piezo voltage adjustments of the feedback loop. Deflection images show the error signal associated with the feedback loop. The deflection signal (error signal) is small when parameters during imaging are optimized, therefore the deflection images are usually not reported in the literature. As the tip is scanned across and interacts with the sample, frictional force will cause lateral twisting of the tip. The lateral movement of the laser spot on the photodetector is used to generate lateral force images. The lateral force images are used to distinguish the differences in chemistry at the interface.

An example of contact-mode imaging is shown in Figure 2.2. Gold terraces and step edges under a monolayer of 1,1,1-tris(mercaptomethyl)heptadecane (TMMH) are apparent in the topography frame (Figure 2.2a). Nanopores with a depth of ~0.6 nm can vaguely be distinguished in the topograph, however, in either the trace or retrace of the lateral force images, differences between the methyl terminal group of TMMH and the circular spots of bare gold substrate are clearly revealed. Interestingly, the contrast is reversed between the trace and retrace images. The nanopores are shown as bright spots with a darker color for the TMMH layer in the trace image

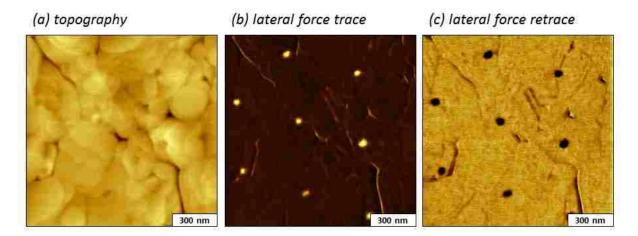


Figure 2.2 Nanopores within a thin film of 1,1,1-tris(mercaptomethyl)heptadecane on Au(111) are viewed in the topograph (a), lateral force trace (b), and lateral force retrace (c) images acquired using contact-mode AFM.

(Figure 2.2b); whereas the nanopores are dark with brighter areas for TMMH in the retrace image (Figure 2.2c). As the tip scans the surface in opposite directions the probe interacts with the surface differently to produce a reversion in contrast between trace and retrace images of lateral force channel.³⁵

2.3 AFM Force Spectroscopy

Quantitative measurements of interactions between the tip and sample can be achieved with AFM force spectroscopy to generate force-distance curves. ³⁶⁻³⁹ Force spectroscopy has been applied for probing the kinetics of chemical reactions on surfaces,⁴⁰ for studies of the glass-to-rubber transition of amorphous polymers, the elastic-plastic properties as a function of temperature,⁴¹⁻⁴² adhesion,⁴³ and time-dependent elastic response of polymers.⁴⁴ A force-distance curve is a plot of cantilever deflection as a function of tip position in the z direction of an approach-retract cycle. Forces between the tip and sample can be calculated by Hooke's Law (Equation 2.1).

$$F = -kx$$
 Equation 2.1

For this relation, F is the force applied to the tip from the sample, k is the spring constant of the cantilever, and the x is the cantilever deflection.

Based on Hooke's Law, the force sensed by the probe is proportional with the tip displacement, which can also be viewed in the example of a force-distance curve (Figure 2.3) acquired in air for nanopatterns of octadecyltrichlorosilane on Si(111). In region I, the tip is far away from the sample and no force is present between the tip and sample, thus there is no cantilever deflection. As the tip is brought closer to the surface, attractive forces (such as Van der Waals or electrostatic forces) cause the tip to "snap into contact" with the sample (region II). In region III, the tip is placed in contact with the sample in the repulsive force region. The increase in force causes the tip to bend. When reaching the set maximum force (maximum bending), the retract cycle begins (region IV). Adhesion in region V maintains contact of the tip and sample. When the

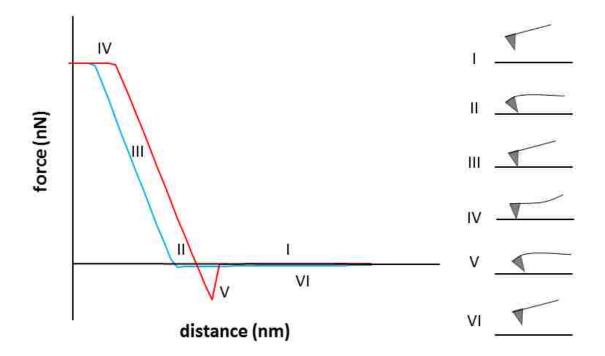


Figure 2.3 Force-distance curves acquired in air with Si_3N_4 tip for a sample of nanopore patterns on Si(111): approach (blue) and retract (red) cycle.

distance between the tip and sample is large enough, the tip will "snap out of contact" and return to zero deflection (region VI).

2.4 Tapping-mode AFM and Phase Imaging

Lateral, adhesive and shear forces may displace loosely bound molecules or damage soft samples on surfaces such as nanoparticles,⁴⁵ polymers,^{7, 46-48} and proteins.⁴⁹⁻⁵⁰ Tapping-mode AFM was developed to minimize damage to the sample caused by shear forces.⁵¹⁻⁵³ During tapping-mode imaging the AFM probe is operated to gently "tap" the surface. The probe is driven to oscillate by a piezoceramic element at or near the resonance frequency (150-400 kHz). Tapping-mode tips are stiffer than probes used for contact-mode imaging, with spring constants in the range of 10-50 N/m. The oscillation amplitude of the tips for tapping-mode is around 50-100 nm, which is adequate to overcome adhesion between the tip and sample. The tip is mounted on a scanner (Figure 2.4). To induce vibration of the tip, AC voltage is applied to a piezoactuator inside the tip

holder assembly. The amplitude of free oscillation in air will be dampened when the tip encounters the sample. A feedback loop maintains a constant amplitude at a designated setpoint value. The difference between the output or measured amplitude with the amplitude setpoint value is the error signal for tapping-mode imaging. The error signal is used to calculate how much voltage is needed to maintain a constant amplitude within the feedback loop. Changes in the voltage to maintain a constant amplitude are translated to generate digital topography images.

Phase images provide additional information and can be acquired concurrently with tapping-mode topography frames. Differences in the phase angle between the driving AC input signal and the output tip vibration, also called the phase lag (Figure 2.4), are measured by a lock-in amplifier and translated into phase images. Information of local adhesion, viscoelasticity and contact area slope between tip and sample can be sensitively mapped with phase images.⁵⁴⁻⁵⁵

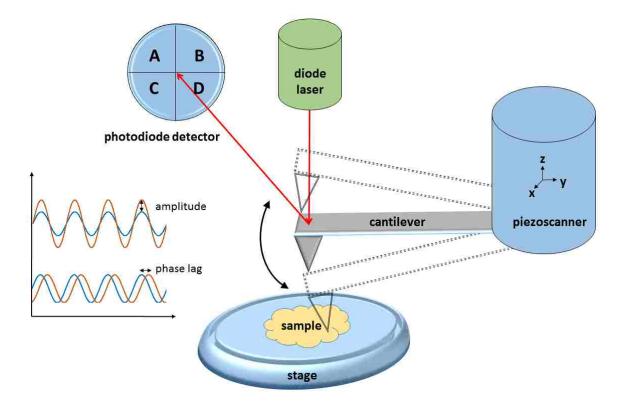


Figure 2.4 Operating principle of tapping-mode AFM.

An example of tapping-mode topography and phase images is shown in Figure 2.5 for a sample of patterned nanorings of *N*-(6-aminohexyl)aminopropyltrimethoxysilane prepared using particle lithography with chemical vapor deposition.⁵⁶ The surface morphology and a height profile of the nanoring sample are presented in the topography channel, where brighter contrast indicates the taller structures on surface (surface z scale: 5.7 nm). The difference in color contrast among the ring, the center areas of the ring, and the surrounding matrix areas shown in the phase images indicate changes in elastic response for different regions of the sample. The small particles between the rings can be clearly resolved in the phase image.

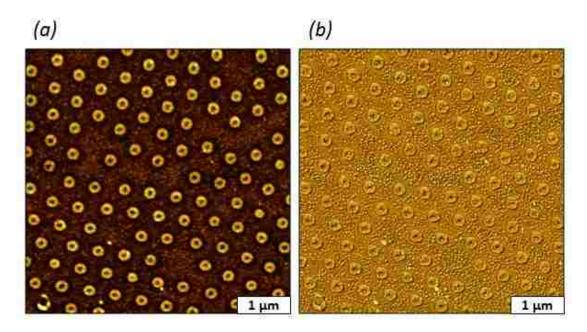


Figure 2.5 Nanorings of *N*-(6-aminohexyl)aminopropyltrimethoxysilane imaged with tapping-mode AFM. (a) Topography and (b) phase images.

Tapping-mode is particularly suitable for polymer samples which have viscoelastic properties. Phase images can elucidate fine details of the sample that topography cannot provide, especially for phase separated system such as polymer blends of polystyrene and polybutadiene,⁵⁷ lamellae structure of block copolymer polystyrene-*b*-polymethylmethacrylate,⁵⁸ and segmented

polyether polyurethane.⁵⁹ An example of tapping-mode imaging of polymeric materials is presented in Figure 2.6 for a bottlebrush copolypeptoid, norbornenyl-terminated $poly(N-ethyl glycine)_{36}$ -*r*-poly(*N*-butyl glycine)₁₂ copolymers. The sizes and shapes of the bottlebrush polymer were studied with tapping-mode AFM. Discrete nanosized particles are viewed in the topograph and corresponding phase image. The differences in the shapes are attributed to the orientation and twisting of the polymer backbone or aggregation of several polymer molecules. The individual domains within one particle can be visualized in phase image, which cannot be clearly seen in topography channel.

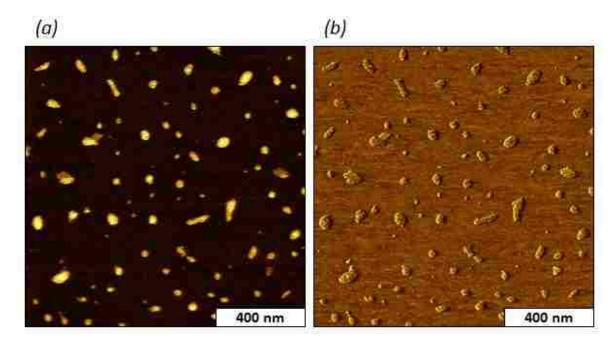


Figure 2.6 Example of composition mapping of bottlebrush polypeptoid norbornenylterminated $poly(N-ethyl glycine)_{36}$ -*r*-poly(*N*-butyl glycine)_{12} copolymers prepared on a mica substrate imaged with tapping-mode. (a) Topograph with z scale of 2.0 nm and (b) phase image.

2.5 Force Modulation Microscopy

Force modulation microcopy (FMM) was invented in 1991 by Maivald and Hansma et al.¹⁴ The FMM mode is used to measure the dynamic response of samples while applying modulated pressure to surfaces during contact-mode imaging. Measurements of elasticity and viscoelasticity can be acquired with FMM. Materials that have been studied with FMM include patterned selfassembled monolayers (SAMs),⁶⁰ polymer blends and resins,⁶¹⁻⁶⁴ protein-lipid aggregates,⁶⁵ wood cells and fibroblasts,⁶⁶⁻⁶⁸ bacteria,⁶⁹ porous silicon,⁷⁰ as well as optical thin film materials.⁷¹ Quantitative measurements such as Young's modulus⁷²⁻⁷⁴ and the elasticity⁷⁵⁻⁷⁶ of samples can be evaluated using FMM.

For force modulation microscopy, the tip is operated in contact-mode, which means the tip is operated in continuous contact with the surface during scanning. Either the sample or tip is driven to vibrate with pressure applied at the area of tip-sample contact. Most commonly FMM has been done using an instrument configuration with the sample placed directly on top of an xyz scanner and actuation of the z piezoelement causes the sample to vibrate for tip displacements of a few nm in the z-direction.^{62, 77-82} For a scan-by-tip AFM configuration, an FMM sample stage was invented by our group in collaboration with Dr. Song Xu and Sonimoto Laboratory to facilitate FMM measurements. Machined polycarbonate was used to construct the sample stage. Current can be applied through a coxial cable connection to the piezoactuator within the stage to generate z axis vibration. Details of the FMM sample stage will be presented in Chapter 6.

Other than stage-driven FMM, tip-vibration FMM has been developed and applied. For example, a cantilever holder equipped with bimorph piezoelements was used to accomplish force modulation, which can actuate the tip as it is pressed against the sample.^{63, 83-84} A magnetic field has been used to drive the vibration of a tip or tip-holder assembly to accomplish force modulation imaging.^{76, 85-88} One way to use magnetically actuated system, named indirect magnetic modulation (IMM), was introduced by our group.⁸⁶ For IMM, an AC current is applied to a MAC mode sample stage and an electromagnetic field is generated from a solenoid underneath the MAC stage. A tip-holder assembly or nosecone containing ferromagnetic material is induced to vibrate

with the flux of the electromagnetic field. The AFM is operated in contact-mode, therefore, information of height, elasticity and adhesion are simultaneously acquired. The vibration frequency and amplitude can be tuned to obtain the highly sensitive images.⁸⁹ Comparison of FMM using the newly designed sample stage and IMM will be presented in Chapter 7.

An example of indirect magnetic modulation imaging is shown in Figure 2.7. Patterned nanorings of 2-[methoxy(polyethyleneoxy)propyl]trichlorosilane (PEG-silane) prepared using particle lithography combined with silane vapor deposition were imaged with IMM at frequency 266 kHz. Identical information can be obtained from IMM and contact-mode topographs, which are height profiles of the surface (surface z scale: 1.5 nm). The nanorings protrude from the surface shown in the Figure 2.7a. The amplitude channel represents the softness and hardness of the sample, showing brightest contrast for the center of the ring and darkest for the ring. The center of the ring is the hard silicon substrate and the ring is a softer PEG multilayer. When presses a soft surface, the amplitude of the tip is dampened.

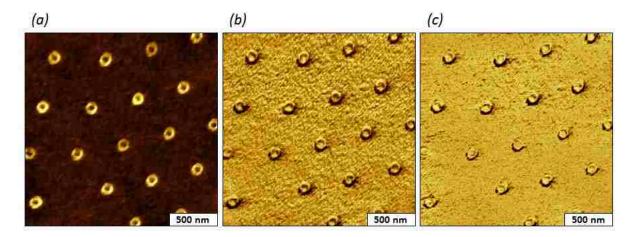


Figure 2.7 Nanorings of 2-[methoxy(polyethyleneoxy)propyl]trichlorosilane imaged with indirect magnetic modulation at vibration frequency of 266 kHz. (a) Topography, (b) amplitude, and (c) phase images.

2.6 In Situ Temperature Studies Using AFM

Dynamic studies with time-lapse AFM experiments using a heating stage have been reported.⁹⁰ The crystallization and melting of poly(ethylene oxides) and polyethylene,⁹¹⁻⁹² the crystal-mesophase transition of poly(di-n-hexylsilane) and poly(di-n-butylsilane),⁹³ the phase transition behavior of single thermo-responsive hydrogel particles: poly(*N*-isopropylacrylamide-co-acrylic acid),⁹⁴ the phase transition of a nanocomposite,⁸⁶ and diblock copolymer domains in directed self-assembly have been investigated *in situ* using AFM.

An example of a sample stage with temperature control is shown in Figure 2.8. This is the stage used in Chapter 4 for an *in situ* study of thermos-responsive polypeptoids. The yellow metal piece in the center of stage (Figure 2.8a) is used to heat the sample. The metal pin on the back of the stage (Figure 2.8b) is used to connect the stage with the control box (Figure 2.8c). The stage can be heated up to 250 C with accuracy up to ± 0.025 C with low thermal drift.

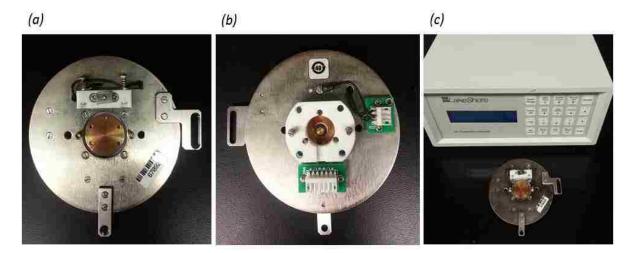


Figure 2.8 Photographs of the heated stage and control box. (a) Front side of the heated sample stage. (b) Backside of the heating sample stage. (c) Control box and the heated stage.

2.7 AFM imaging Modes Used in the Dissertation

An overview of the imaging modes used in this dissertation is outlined in Table 2.1. The imaging modes were selected based on the surface properties of samples. Force modulation

microscopy using the designed sample stage versus indirect magnetic modulation are compared in

Chapter 7.

Chapter	Sample description	Contact- mode	Tapping- mode and	<i>In situ</i> temperature	Force modulation	Indirect magnetic
	uesemption	and	phase	study	using new	modulation
		lateral	imaging	5	stage	
		force				
		imaging				
3	Poly (N-allyl	Х	Х			
	glycine)					
	"grafted from"					
	Si(111)					
4	Copolypeptoids	Х		Х		
	"grafted to"					
	Si(111)					
6	Organosilane				Х	
	nanopatterns					
	and polymeric					
	gels					
7	Nanorings of				Х	Х
	organosilanes					

Table 2.1 Modes of SPM used in Dissertation Research Experiments

CHAPTER 3. DIRECTED GROWTH OF POLYMER NANOPILLARS USING SURFACE-INITIATED RING-OPENING POLYMERIZATION OF *N*-ALLYL *N*-CARBOXYANHYDRIDE

3.1 Introduction

Peptide-functionalized thin films have been applied as stimuli responsive materials,⁹⁵ antifouling agents⁹⁶⁻⁹⁷ and as inorganic/peptide hybrids.⁹⁸ Poly(α -peptoid)s, a class of pseudo-peptidic polymers, feature a polyglycine backbone with substitution on the nitrogen atoms.⁹⁹⁻¹⁰⁰ The biocompatibility, backbone degradability and processability of poly(α -peptoid)s make these polymers useful for applications such as smart coatings, biosensors and bioseparations.⁹⁹ There are relatively few publications reporting studies of polypeptoid thin films¹⁰¹ or reports focusing on nanopatterns of polypeptoid brushes on surfaces. Surface structures of peptides have previously been reported to accomplish micron-scale patterning using photolithography¹⁰²⁻¹⁰³ and microcontact printing.¹⁰⁴⁻¹⁰⁵ We report results for combining particle lithography with surface-initiated ring-opening polymerization of *N*-allyl *N*-carboxyanhydride (allyl-NCA) to prepare polymer pillars of poly(*N*-allyl glycine).

To prepare polypeptide/peptoid brushes, there are two commonly used methods, "graft to" and "graft from".¹⁰⁶⁻¹⁰⁷ The "graft to" approach involves a reaction between surface reactive moieties and the end-groups of pre-synthesized polypeptide/peptoid. The method is experimentally simple however it is difficult to achieve high grafting densities because of the steric crowding. The "graft from" method, also known as the "surface-initiated" approach, occurs through a ring-opening polymerization of α -amino acid *N*-carboxyanhydride (NCAs) with initiators attached to surfaces. Control of the functionality, density and thickness of polymer nanopillars with molecular precision using the "graft from" approach can be readily achieved.¹⁰⁶

Amine-functionalized substrates in either solution or vapor phase were used to prepare thin films of polypeptide brushes using surface-initiated polymerization (the "graft from" method).¹⁰⁸⁻

¹¹⁴ The "graft from" and "graft to" approaches for grafting poly (y-benzyl-L-glutamate) (PBLG) film on silicon oxide surface was reported in 1996.¹⁰⁹ To obtain better control of PBLG film thickness, a protocol with vapor deposition polymerization was developed which involved a reaction between the vapor species of y-benzyl-L-glutamate and a primary amine modified silicon substrate.¹¹⁰ The vapor deposition method was improved so that the α -helical PBLG films were fabricated in less than 1 h with tunable thickness from a few nanometers to hundreds of nanometers.¹¹⁵ Mechanistic studies of surface-initiated vapor deposition polymerization of PBLG were reported by Zheng *et al.*¹¹⁶ The helix orientation of PBLG and poly(γ -methyl *L*-glutamate) (PMLG) were studied using FT-IR transmission spectroscopy.¹¹⁷⁻¹¹⁹ The surface-grafting of ABblock copolypeptides, PBLG-b-PMLG, was also introduced.¹¹⁹ Synthesis of surface-tethered poly(L-glutamic acid) (PLGA) and poly(L-lysine) (PLL) and the conformational transition (α helix, β -sheet, and random coil) for the responsiveness to the external stimuli of pH, surfactant and ions were investigated using circular dichroism (CD).¹²⁰⁻¹²² Well-defined homo- and blockpolypeptides were prepared by transition metal-mediated polymerization of NCAs, demonstrated by Deming et al.¹²³⁻¹²⁵ Polystyrene particles functionalized with PBLG were obtained by ringopening polymerization of NCAs by nickel amido-amidate complexes.¹²⁶ Thiol-clickable and block copolypeptide brushes were synthesized via a nickel-mediated surface-initiated polymerization resulting in an effective approach to functionalize polypeptide surfaces.¹⁰⁷

Particle lithography, is a facile and versatile fabrication technique applicable for generating nanostructures with regular nanoscale geometries with high reproducibility.¹²⁷ Solutions of monodisperse mesospheres self-assemble into close-packed arrangements on surfaces during evaporation of solvents. The periodic mask that is formed on surfaces can be used for nano- or micron- scale fabrication.¹²⁷⁻¹³¹ The advantages of particle lithography include the generic use of

basic lab equipment and experimental steps, and the capability for tuning the dimensions of surface structures according to the diameters of mesospheres.¹²⁸

Using particle lithography, porous polymer films were prepared using materials, such as polv(*N*-isopropylacrylamide).¹³³ polvethersulfone.¹³⁴⁻¹³⁵ polycaprolactone.¹³² and polythiophene.¹³⁶⁻¹³⁷ The first surface-initiated and site-specific Suzuki polycondensation to quickly and selectively graft polyfluorene from functionalized, sub-micron surface patterns at room temperature was developed by Beryozkina et al.¹³⁸ A range of robust and simple patterning strategies using microsphere arrays as a surface mask were combined with surface-initiated atom transfer radical polymerization to fabricate patterned triangular, ring-shaped, dot-like, or hole-like poly(N-isopropylacrylamide) brush microstructures.¹³⁹⁻¹⁴⁰ Surface-imprinted polymer films for protein recognition were prepared by immobilizing avidin on monodisperse polystyrene beads, then depositing the beads onto gold-coated quartz crystal, followed by electropolymerization of 3,4-ethylenedioxythiophene and finally dissolving away the beads.¹⁴¹ A binary compositionally patterned surface containing poly(carbazole) and poly(*N*-isopropylacrylamide) was prepared via colloidal-template assisted electropolymerization followed by growing the polymer brushes using SI-ATRP.¹⁴²

Particle lithography and organosilane chemistry were used to prepare nanopores within a thin film of octadecyltrichlorosilane (OTS).¹⁴³⁻¹⁴⁴ Uncovered sites of Si(111) were backfilled with (3-aminopropyl)triethoxysilane (APTES) as a means to direct the growth of *N*-allyl *N*-carboxyanhydride (allyl-NCA).¹⁴⁵ Each step during the preparation of the surface platform was characterized by atomic force microscopy (AFM), which has been previously used for studying surface-grafted polymer nanopillars.¹⁴⁶⁻¹⁵¹ The polypeptoid nanopillars have reactive side chains, since allyl-NCA with a pendent allyl group was chosen as the monomer. The polymer can be

further functionalized by thiol-ene click reaction for constructing complex surface structures.¹⁵²⁻

3.2 Experimental Section

3.2.1 Materials and Reagents

Reagents were used as received without further purification. Octadecyltrichlorosilane (OTS) was purchased from Gelest (Morrisville, PA). Anhydrous toluene, bicyclohexyl, (3-Aminopropyl)triethoxysilane (APTES), dichloroacetic acid, chloroform, sulfuric acid (ACS reagent 95%) and hydrogen peroxide (30%) were obtained from Sigma-Aldrich. Pieces of single-sided polished Si(111) doped with boron (Ted Pella, Inc., Redding, CA) were used as substrates. Monodisperse silica mesospheres with diameter $0.49 \pm 0.02 \mu m$ were acquired from Duke, Inc. (Fremont, CA). The deionized water used for experiments was from a Direct-Q3 system (18 M Ω , Millipore, Bedford, MA).

3.2.2 Atomic Force Microscopy

Samples were characterized using either a model 5500 or 5420 atomic force microscope (Agilent Technologies, Chandler, AZ). Nonconductive V-shaped cantilevers made of silicon nitride with force constants ranging from 0.01-0.60 N/m were used for contact-mode imaging (Bruker Probes, Camarillo, CA). Silicon nitride cantilevers with an average force constant of 48 N/m and a resonance frequency of 190 kHz were used for tapping-mode imaging (Vista probes, Phoenix, AZ). Images were processed using Gwyddion open source software which is supported by the Czech Metrology Institute.¹⁵⁵

3.2.3 Preparation of Nanopores within an OTS Film

Particle lithography was used to generate organosilane nanopore patterns on Si(111) surfaces.¹⁴³ The silicon substrates were cleaned by immersion in piranha solution for 2 h. Piranha solution, which is a mixture of sulfuric acid and hydrogen peroxide at a ratio of 3:1 (v/v), is highly

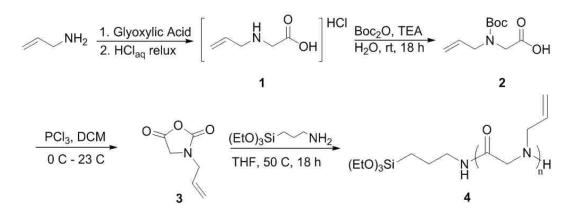
corrosive and should be handled cautiously. Substrates were rinsed copiously with deionized water and dried under argon. Monodisperse silica mesospheres were washed three times by centrifugation to remove trace charge stabilizers or surfactants. The pellet of silica mesospheres was resuspended in water by vortex mixing, and a drop (10μ L) was deposited on a clean substrate. The sample was dried in air for 2 h to produce surface masks for further chemical steps. As water evaporated during the drying step, capillary forces pull the mesospheres together to form crystalline layers on flat surface. Next, the substrate was placed in an oven at 140 C for 24 h to temporarily anneal the mesospheres to the surface. After cooling, the sample was immersed in a 0.1% solution of OTS (v/v) in toluene for 5 h. Next the sample was rinsed with water and ethanol. To remove the mesoparticles, the substrate was sonicated for 15 min in ethanol and water successively. The sample was dried under argon for AFM characterization.

3.2.4 Preparation of APTES Nanodots

The substrate (polished Si wafer) with OTS nanopores was cleaned by sonication in ethanol for 10 min to remove contaminants, then dried under argon. Uncovered bare areas of the Si substrates were backfilled with initiator by immersion in an APTES solution (0.02% v/v solution of APTES in bicyclohexyl for 3 h). Next, the samples were rinsed with acetone, water and ethanol, followed by 15 min sonication in ethanol and in water. The samples were dried under argon and characterized with AFM.

3.2.5 Three Steps Synthesis of Allyl-NCA

Synthesis of 2-(Allylamino)acetic Acid Hydro-chloride: Allylamine (15 mL, 0.2 mol) and glycoxylic acid (30 g, 0.4 mol) were both dissolved in CH_2Cl_2 and stirred at room temperature for a period of 24 h. The solvent was removed and 1 N HCl aqueous solution (300 mL) was added to the flask (Scheme 3.1). The mixture was refluxed overnight at 110 C. The solvent was evaporated to yield brown viscous oil. Recrystallization in cold methanol and THF afforded white crystals



Scheme 3.1 Synthetic procedure for allyl-NCA

(11.53 g, 38% yield). ¹H NMR (δ in MeOD, ppm): 5.7 (m, =CH-); 5.3 (t, =CH₂); 3.7 (s, -CH₂-);
3.5 (d, =CHCH₂-). ¹³C{¹H} NMR (δ in CDCl₃, ppm) 166.3 (C=O); 129.8 (-CH=CH₂); 121.0 (-CH=CH₂); 48.9 (-CH₂-); 46.4 (-CH₂-).

2-(Allyl(tert-butoxycarbonyl)amino)acetic Acid (2): 1 (11.53 g, 0.076 mol) and di-tert butoxide (41.40 g, 0.191 mol) were dissolved in distilled water (250 mL). The solution was stirred, and then triethylamine (53.10 mL, 0.382 mol) was added via syringe. The reaction was stirred overnight at room temperature. The solution was washed with hexanes to remove excess di-tert-butoxide (100 mL) and then the aqueous portion was made acidic using 1N HCl (roughly 150 mL). The aqueous portion was washed twice with ethyl acetate (100 mL) then the combined organic layers were washed once with brine (70 mL). The organic layer was dried with MgSO₄, filtered and then the solvent was removed under vacuum to yield a pale yellow oil (16.2 g, 0.075 mol, 99% yield). ¹H NMR (δ in CDCl₃, ppm): 10.4 (bs, -O*H*); 5.7 (m, =C*H*-); 5.3 (t, =C*H*₂); 3.7 (s, -C*H*₂-); 3.5 (d, =CHC*H*₂-); 1.4 (s, -(C*H*₃)₃). ¹³C{¹H} NMR (δ in CDCl₃, ppm): 173.4 (-NCOO-); 167.1 (-COOH); 131.1 (-CH=CH₂); 119.9 (-CH=CH₂); 78.9 (*C*(CH₃)₃); 49.8 (-CH₂N-); 47.6 (-CH₂CH=); 28.1 (-(CH₃)₃).

Synthesis of Allyl-NCA (3): **2** (16.2 g, 0.075 mol) was dissolved in anhydrous dichloromethane and while under an argon atmosphere, the solution was chilled to 0 C. PCl₃ (7.5 mL, 0.086 mol) was added to the solution via syringe. The solution was stirred at 0 C for one hour, after which the solution was kept at 25 C for 2 h. The solvent was then removed under vacuum and the flask was placed into a glove box. The residue was redissolved in anhydrous dichloromethane, and stirred with NaH for 10 min. The solution was filtered and the filtrate was concentrated, leaving clear oil. The oil was vacuum distilled at 60 C in the modified vacuum distillation apparatus. The final product was a clear liquid (5.94 g, 0.042 mol, 54%). ¹H NMR (δ in Tol-d₈, ppm): 5.2 (m, =CH); 4.8 (m, =CH₂); 3.4 (d, -CH₂-); 2.9 (s, =CHCH₂-). ¹³C{¹H}c NMR (δ in Tol-d₈, ppm): 160.3 (-CH₂C(O)O); 147.0 (-OC(O)N-); 132.1 (-CH=CH₂); 113.7 (CH₂=CH-); 42.4 (=CHCH₂N-); 40.3 (C(O)CH₂N-).

3.2.6 Polymerization of Allyl-NCA.

Substrates with OTS and APTES nanopatterns were immersed for 24 h in 0.43 M allyl-NCA solution in THF at 50 C under N₂. Afterward, the substrates were rinsed with THF and then immersed for 2 days in a mixture of dichloroacetic acid and chloroform at a 1:4 (v/v) ratio to remove physically adsorbed molecules, followed by rinsing with chloroform, water and ethanol. The sample was then dried under argon.¹¹⁷

3.3 Results and Discussion

The strategy for spatially directing the polymerization of allyl-NCA is outlined in Figure 3.1. A close-packed arrangement of silica mesospheres on Si(111) served as a surface mask for defining the sites for depositing of OTS (Figure 3.1a). A masked substrate was immersed in a solution of OTS to enable molecules to self-assemble on areas of exposed Si surrounding the mesospheres (Figure 3.1b). Nanopores within the OTS thin film were produced after removal of silica mesospheres (Figure 3.1c). The initiator (APTES) was selectively grown inside the OTS

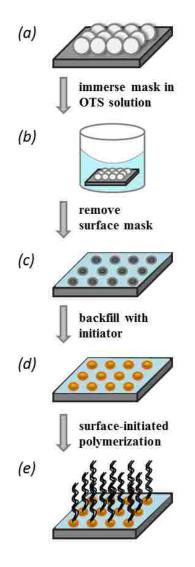


Figure 3.1 Steps for preparing poly(*N*-allyl glycine) nanopatterns. (a) An drop of an aqueous suspension of silica mesospheres was dried on a Si wafer and annealed to provide a surface mask. (b) The sample was immersed in a solution of OTS in toluene. (c) The mask of silica mesospheres was removed by sonication. (d) The uncovered areas within the nanopore were filled with initiator by immersing the sample in an APTES solution. (e) Columnar nanostructures were formed using surface-initiated ring-opening polymerization of *N*-allyl *N*-carboxyanhydride.

nanopores to form a chemically patterned surface (Figure 3.1d). The nanodots of APTES provided sites for spatially selective growth of polymer. Surface-initiated ring-opening polymerization of allyl-NCA took place at sites where the primary amine (APTES) was located (Figure 3.1e).

Preparation of Nanopores within a Film of OTS. Particle lithography was used to generate OTS nanopores described in step c of Figure 3.1 as the first step of sample preparation. Nanoscale views of the nanopores are shown in Figure 3.2 with successive zoom-in topography images acquired with contact-mode AFM. The nanopores within a matrix film of OTS form a periodic arrangement according to the locations of the mesospheres of the surface mask. The topographs (Figures 3.2ac) display dark spots where the mesospheres were rinsed away to reveal the Si substrate. The widearea topography frame of Figure 3.2a ($6.7 \times 6.7 \ \mu m^2$) discloses the regular arrangement of 211 nanopores, which would scale to $\sim 10^9$ nanopores per cm². Approximately 97% of the surface is covered with OTS. Zoom-in views of the nanopores reveal slight differences in the shapes and sizes of the nanopores (Figures 3.2b and 3.2c). The imperfections are caused by factors such as the nanoscale variations in mesoparticle sizes and the roughness of the polished silicon wafers. The lateral dimensions of the nanopores measure 108 ± 29 nm. Bright spots indicate the shapes and locations of nanopores in the lateral force frame of Figure 3.2d. The slight differences in the sizes of surface sites will eventually propagate into size variations for polymer nanostructures. The nanopores do not appear to contain OTS according to the contrast of the lateral force frame (Figure 3.2d). In lateral force images, the color contrast is attributable to chemical differences for local areas of samples. The distance between two nanopores shown in Figure 3.2e measures ~500 nm, which matches the size of the silica mesospheres $(490 \pm 20 \text{ nm})$ used for the surface mask (Figure 3.2e). The depth of the nanopores measures 1.9 ± 0.1 nm, which is smaller than the reported height of a densely packed, upright monolayer of OTS (~2.6 nm).¹⁵⁶ The shorter height indicates that the molecules within the OTS film are not densely packed.

The nanopores within the OTS matrix were used as a foundation for further patterning steps to form polypeptoid nanostructures. Methyl terminal groups of OTS are presented at the interface

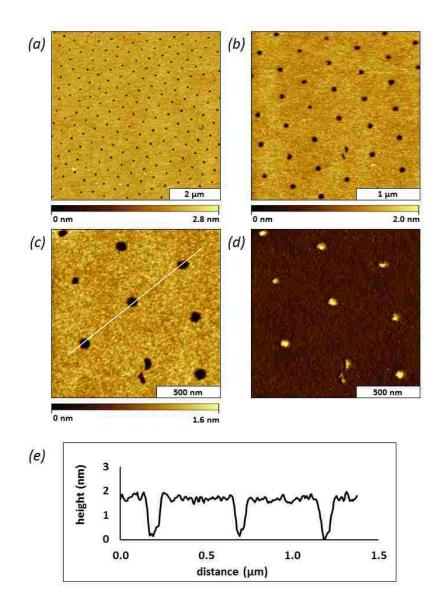


Figure 3.2 Nanopores within a film of OTS prepared using 500 nm silica mesospheres. (a) Contact-mode AFM topography image of nanopatterns prepared on Si(111). (b) Zoom-in view. (c) Magnified view of nanopores and (d) simultaneously acquired lateral force image. (e) Cursor profile for the line in c.

to furnish a resist layer that does not react with allyl-NCA for patterning of polypeptoid. The nanoscopic bare areas of the Si substrate within the nanopores provide hydroxyl groups to spatially define sites where amino-silane molecules will bind to grow polymer nanostructures.

Selective Filling of APTES Initiator into Nanopores. The initiator (APTES) molecules assembled into the uncovered areas of the Si substrate within OTS to form regular nanodot patterns, as shown in Figure 3.3. The bright spots are backfilled APTES nanodots and the darker areas in the background are the OTS matrix (topography frame, Figure 3.3a). The hexagonal arrangement

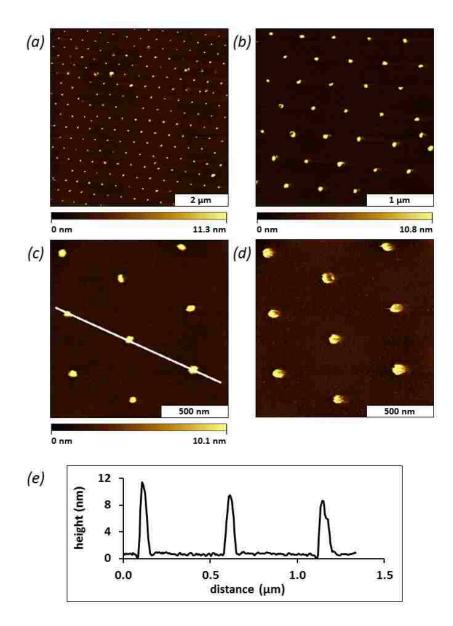


Figure 3.3 After selective filling of the nanopores with APTES, surface views with contactmode AFM. (a) The nanodots of APTES are taller than the surrounding OTS resist in the topography images, $6.7 \times 6.7 \,\mu\text{m}^2$; (b) zoom-in topograph; (c) close-up view of eight nanodots with (d) corresponding lateral force image. (e) Height profile for three nanodots indicated in *c*.

of APTES nanodots are apparent in Figures 3.3b and 3.3c. There are 38 nanodots in Figure 3.3b, which accordingly scales to ~ 10^9 nanodots per cm². The results indicate that OTS is an excellent resist since the growth of APTES was confined to areas inside the nanopores. The surface contains chemical patterns of methyl and amine terminal groups for further steps of site selective polymer growth. The differences in surface chemistry are distinctly apparent in the high-resolution lateral force image of Figure 3.3d. The height of the nanodots measured 10 ± 1.2 nm (including the depth of the nanopores), which corresponds to multilayers of APTES. The height of three selected APTES nanodots are shown in Figure 3.3e as an example measurement. The lateral dimension of the APTES nanodots measured 110 ± 25 nm, which matches the dimensions of the unfilled nanopores.

Polymerization of Allyl-NCA to Form Nanopillars. The primary amine functional groups on the nanodots of APTES were used to initiate polymerization of allyl-NCA to form columnar nanopillars. Although APTES formed multilayers, the initiation reaction should still take place since amine groups are present at the interface. Columnar nanopillars of poly(*N*-allyl glycine) are shown in Figure 3.4, imaged using tapping-mode AFM. The round bright spots are polypeptoids grown on APTES nanodots, and the darker areas are the surrounding matrix film of OTS. The periodicity of the nanopatterns is retained after polymerization as revealed in the wide-area topograph of Figure 3.4a. The image is representative of the entire sample, with ~97% surface coverage of OTS and ~3% coverage of poly(*N*-allyl glycine). Views of individual nanopillars disclose the slight differences in shapes and heights of the nanostructures (Figure 3.4b). A few adsorbates are present between poly(*N*-allyl glycine) pillars. The heights of two representative polymer nanopillars are shown in Figure 3.4c. The average height measured 16 nm which indicates that the degree of polymerization is approximately 14 (the height of the multilayer of APTES was

removed from the calculation). The tallest nanostructure is 35 nm, which shows the highest degree of polymerization assuming that the polymer backbone is fully stretched (~62). The shortest nanostructure is 10 nm, which is the same height as the APTES nanodots indicating that no polymerization took place at some sites (10% of the polymer nanodots). The lateral dimension of the polypeptoids measured 110 ± 13 nm, which closely matches the lateral dimensions of APTES nanodots. The heights suggest that poly(*N*-allyl glycine) growth is predominantly in the z direction,

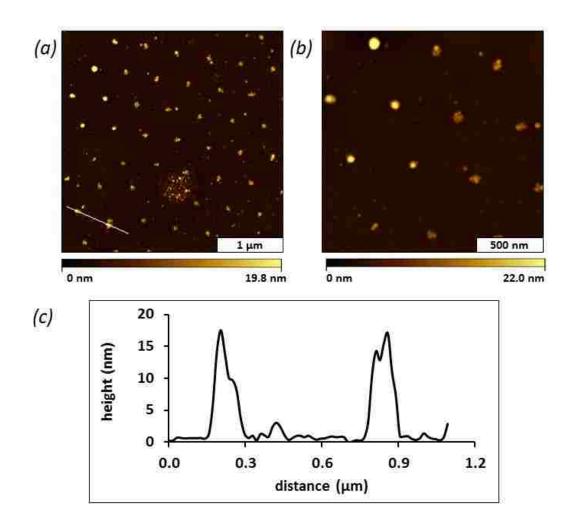


Figure 3.4 Surface-initiated ring-opening polymerization of *N*-allyl *N*-carboxyanhydride on sites with APTES nanodots. (a) Nanostructures are taller after steps of polymerization, shown in the topographs; (b) zoom-in view of polypeptoid pillars; (e) Cursor profile for two nanopillars in a.

rather than growth of wider nanostructures. The distance between two polymer nanopillars measured ~500 nm, corresponding to the expected dimensions of the silica mask.

The APTES initiated ring-opening polymerization of allyl-NCA in solution is a living polymerization. When polymerization occurs on the surface, the reactivity of molecules is spatially restricted. Since the sizes of the nanopores are slightly different, the number of APTES molecules within a single nanopore varies, which influences the chain lengths of poly(*N*-allyl glycine). With increase of the nanopore size, the heights of the polymer nanopillars correspondingly increased. However the growth did not correspond to a linear relation. The drawback of using the "graft from" method leads to an increased difficulty in controlling both the initiation and propagation steps.

Three Key Steps of Preparing Patterned Poly(*N***-allyl glycine**). The key steps to prepare patterned polymer nanopillars are shown in Figure 3.5. Nanopores within a film of OTS were prepared using particle lithography combined with silane immersion (Figure 3.5a). The APTES initiator was backfilled into exposed sites of OTS nanopores and formed nanodots (Figure 3.5b). Polymerization of allyl-NCA occurred selectively at sites where APTES nanodots were located (Figure 3.5c).

The changes in height between each step are apparent from the topography views (Figure 3.5). The depth of the nanopores measured 1.9 ± 0.1 nm, while the short nanodots formed after backfilling APTES have average height 10 ± 1.2 nm. The average length of the polymer chains measured 6 nm. The height of the APTES showed a substantial change during the 3 h immersion step, as compared with one day of growth for allyl-NCA. The difference in growth for organosilane molecules is attributable to the capability to readily polymerize with moisture in the system.¹⁵⁷⁻¹⁵⁸ The polymerization step shows a few areas of nonselective growth in the surrounding OTS matrix, since small amounts of adsorbed polymer or monomer attached to the surface and could not be

fully rinsed away (Figure 3.5c). 2) Also, nanoscopic amounts of water on the surface will initiate the polymerization of allyl-NCA.

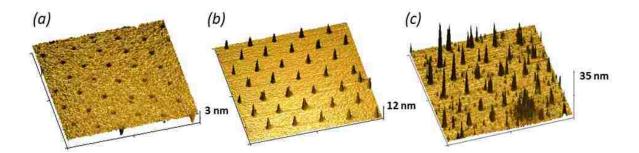


Figure 3.5 Key steps for making patterned poly(*N*-allyl glycine) nanopillars by surfaceinitiated ring-opening polymerization. $(2.7 \times 2.7 \,\mu\text{m}^2 \text{ topographs})$ (a) Nanopores within a film of OTS; (b) nanodots of APTES filled into the exposed sites of nanopores; (c) nanopillars of poly(*N*-allyl glycine).

3.4 Conclusion

The polymerization of allyl-NCA was studied within spatially confined, well-defined nanoscale sites. Nanoscale patterned poly(N-allyl glycine) pillars were prepared on Si(111) by surface-initiated ring-opening polymerization. Nanopores within a self-assembled monolayer of OTS were generated using particle lithography combined with steps of immersion in solution. Molecules of APTES were backfilled into nanopores within a template film of OTS, to form patterned nanodots as sites to initiate the polymerization of allyl-NCA. The clickable side chain of the polymer nanopillars can be functionalized for future applications. The biocompatibility, biodegradability of poly(N-allyl glycine), and control of the distance between polymer nanopillars make this surface platform potentially useful in biomedical and biosensor applications.

CHAPTER 4. THERMO-RESPONSIVE BEHAVIOR OF LINEAR COPOLYPEPTOID NANOSTRUCTURES INVESTIGATED WITH ATOMIC FORCE MICROSCOPY

4.1 Introduction

Thermo-responsive surfaces formed by polymeric materials have received recent attention due to the potential applications.¹⁵⁹ Among the polymeric materials, poly(N-isopropyl acrylamide), or PNIPAAm, is the most often studied system due to its lower critical solution temperature (LCST of 32 C), just below the human physiological temperature (37 C).¹⁶⁰⁻¹⁶³ Temperature-responsive surfaces prepared with PNIPAAm have been investigated for applications in tissue culture and microfluidics,¹⁶⁴⁻¹⁶⁵ display and sensor technology,¹⁶⁶ cell-seeding and co-culture.¹⁶⁷ Surface grafted PNIPAAm on regenerated cellulose membranes have thermally modulated permeability.¹⁶⁸ Responsive copolymer systems having PNIPAAm segment have been studied.¹⁶⁹⁻¹⁷⁴ For example, poly(N-isopropylacrylamide-co-dopamine methacrylamide) was synthesized and attached to a Si wafer for cell sheet applications.¹⁶⁹ A gold nanoparticle with surface-linked poly(styrene-*b*-*N*isopropylacrylamide) copolymer formed temperature-responsive core-shell micelles.¹⁷⁰ Other thermo-responsive polymers have been used to make stimuli-responsive surfaces, including poly[di(ethyleneglycol)methyl ether methacrylate],¹⁷⁵ poly[oligo(ethylene oxide)monomethyl ether methacrylate]-based star polymers,176 gradient and block copolymers based on 2-(2methoxyethoxy)ethyl methacrylate,¹⁷⁷ acetylated

poly-N-[tris(hydroxymethyl)methyl] acrylamide,¹⁷⁸ as well as other systems.¹⁷⁹⁻¹⁸¹

The two common methods to decorate surfaces with polymer are the "grafting from" and "grafting to" methods. The "grafting from" method, usually occurs through a surface-initiated polymerization of selected monomers. Using this method, the grafting density is nearly quantitative, but at the expense of control of the polymer brushes (which tend to have broader molecular weight distributions than polymer brushes from the "grafting to" method).¹⁸² The

"grafting to" approach involves the coupling reaction between surface reactive moieties and the end-groups of functionalized polymer. Though this method having the advantages of controlling the brush polymer molecular weight, architecture and microstructure, high grafting densities are compromised due to steric crowding.

Many "grafting to" approaches use click reactions to prepare surface tethered polymer brushes because the reaction proceeds with high yields and no byproducts.¹⁸³⁻¹⁸⁵ Among several types of click reactions, the copper (I) catalyzed azide-alkyne cycloaddition (CuAAC) is most widely used.¹⁸⁶⁻¹⁹⁶ Three examples of CuAAC are ligand α -acetylene-poly(*tert*-butyl acrylate) with alkyne end group attached to azide functionalized γ -Fe₂O₃ nanoparticles,¹⁹⁷ temperature sensitive nanocomposites of immobilizing thermo-responsive PNIPAAm on Au nanoparticles,¹⁹⁸ and polystyrene/polyacrylamide functionalized silica nanoparticles with the combination of living radical/tandem polymerization and azide-alkyne click reaction.¹⁹⁹⁻²⁰⁰ Azide-alkyne and thiol-ene click reaction can be used at the same time, as demonstrated previously by others, to form binary polymer brushes on silica spheres, followed by removal of the inorganic silica core in hydrogen fluoride solution to obtain hollow polymer nanospheres.²⁰¹ The thiol-ene click reaction is a less commonly used click coupling reaction. However, this reaction is still a efficient, rapid and nearly quantitative method to tether polymers to surfaces.²⁰²⁻²⁰⁴ A major advantage of thiol-ene chemistry is that this method leaves no trace metal residues in the system as compared with azide-alkyne reaction.²⁰²⁻²⁰⁴ As demonstrated with poly(oligo(ethylene glycol)methyl ether methacrylate) coated titanium dioxide nanoparticles, the thiol-ene reaction can reduce particle aggregation and cellular uptake as well as diminish cytotoxicity.²⁰⁵

Thiol-functionalized linear random copolypeptoid poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine₁₇)], or P(NEG₃₂-*r*-NBG₁₇), was synthesized in solution phase. Particle lithography and

thiol-ene click reaction were combined to pattern the copolypeptoids on a surface. The thermoresponsiveness of patterned copolypeptoids was studied using *in situ* atomic force microscopy (AFM). Unlike homogeneous film on surface, this work shows the thermo-responsiveness of the polymer nanopillars on surface are more pronounced and easier to detect. The *in situ* studies of the thermo-responsiveness of patterned polymer pillars at the nanoscale will be discussed for the first time.

4.2 Experimental Section

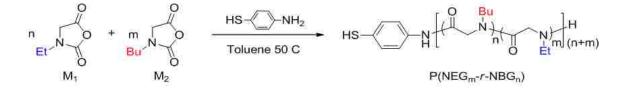
4.2.1 Preparation of Nanopatterned UTS Sites

Nanopores within a thin film of OTS on Si wafer were prepared with a previously reported method.²⁰⁶ The diameter of the silica mesospheres used in the experiment is $0.49 \pm 0.02 \,\mu\text{m}$ (Duke, Inc. Fremont, CA). The substrate with OTS nanopore patterns was characterized with AFM and the result is shown in Appendix Figure C1. The patterned bare areas of the Si substrate were backfilled with UTS by immersing substrate in UTS solution (0.1% v/v solution of UTS in bicyclohexyl) for 5 h. Next, the sample was rinsed with three solvents (water, THF and ethanol), followed by sonication in ethanol and sonication in water to remove excess amount of silane. The sample was characterized with contact-mode AFM in air.

4.2.2 Synthesis of Linear poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine)₁₇] Copolymer

The copolymer was prepared based on previous report.²⁰⁷ Inside the glovebox, *N*-ethyl *N*-carboxyanhydride (137.0 mg, 1.062 mmol) and *N*-butyl *N*-carboxyanhydride (55.6 mg, 0.354 mmol) were dissolved with 1.0 mL toluene in a vial. 4-aminothiophenol (3.5 mg, 0.0283 mmol) in 2.9 mL toluene was added to the monomer solution (Scheme 4.1). The vial was sealed under nitrogen and stirred at 50 C for 27 h. An aliquot of the reaction mixture was taken for conversion analysis. Excess cold hexane was added to the reaction solution to precipitate the polymer. White solid was collected by filtration, washed with hexanes, and dried under vacuum (86 mg, 44% yield).

Size exclusive chromatography (Mw = 14.5 kDa, PDI = 1.24). ¹H NMR (δ in CD₂Cl₂, ppm): 0.82-1.00 (bt, CH₃CH₂-, NBG), 1.05-1.21 (bt, CH₃CH₂-, NEG), 1.23-1.70 (bm, -CH₂CH₂CH₃), 3.13-3.64 (bm, - NCH₂CH₃, -NCH₂CH₂-), 3.88-4.43 (bm, -COCH₂-). (1H NMR spectrum in Appendix Figure C4).



Scheme 4.1 Copolymerize *N*-ethyl *N*-carboxyanhydride and *N*-butyl *N*-carboxyanhydride with initiator 4-aminothiophenol.

4.2.3 Preparation Nanopatterned Poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine)₁₇] by Surface Thiol-ene Click Reaction

Copolymer (10 mg) and photoinitiator Irgacure (10 mg) were added in 2 mL of THF. Si substrate with UTS patterns was immersed in the THF solution and placed under UV lamp (Xenon Arc Lamp) overnight (18 h). Substrate was then rinsed with THF and sonicated, first in THF and second in ethanol. The sample was characterized with AFM the contact-mode in water.

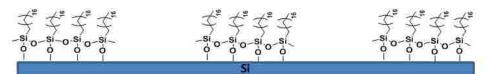
4.2.4 Thermoresponsive Study of Nanopatterned Copolypeptoids using in situ AFM

A sample stage with a water-filled liquid cell is used to hold sample of patterned copolypeptoids on Si wafer. A temperature controller is connected with the sample stage which can adjust the temperature of the sample plate, as well as the sample. The polymer nanopillar height and morphology changes of the copolypeptoids with the increase of temperature were tracked with *in situ* AFM.

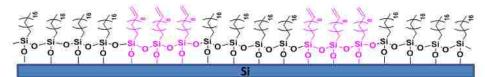
4.3 Result and Discussion

The key steps of preparing nanopatterned random copolypeptoid P(NEG₃₂-*r*-NBG₁₇) on Si substrate are illustrated in Figure 4.1. First, periodically ordered nanopores within a thin film of octadecyltrichlorosilane (OTS) were prepared to provide nano-confined reactive sites through

(a) Preparation of Nanopores



(b) UTS Backfilling of Nanopores



(c) Surface Thiol-ene Click Reaction

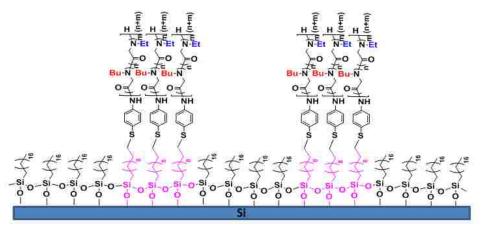


Figure 4.1 Steps for preparing nanopatterns of thermo-responsive copolypeptoids. (a) Nanopores within a film of OTS were prepared by particle lithography and silane immersion. (b) Backfilling of UTS into nanopores to form reactive sites for localizing random copolypeptoids. (c) Linear poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine)₁₇] copolymers, P(NEG₃₂-*r*-NBG₁₇), immobilized at UTS sites through thiol-ene click reaction.

silane hydrolysis and condensation reaction with hydroxylated surface and subsequent removal of silica mesospheres (Figure 4.1a). Second, 10-undecenyltrichlorosilane (UTS) was backfilled into

the nanopores which are the locations of bare Si substrate (Figure 4.1b). Third, the chemically patterned surface was immersed in a tetrahydrofuran (THF) solution containing a thiol end-group functionalized $P(NEG_{32}-r-NBG_{17})$, a random copolypeptoid product of reaction shown in Scheme 4.1. The thiol-ene click reaction occurred between the vinyl group of UTS and thiol end group of polypeptoid upon the irradiation of UV light to form nanopatterned linear random copolypeptoids (Figure 4.1c).

Patterned nanopores within a film of OTS were prepared with particle lithography and silane immersion with a previous reported method in our group (Appendix Figure C1).²⁰⁶ The thin film of OTS served as a polymer deposition resist. The second silane, UTS, filled the nanopore areas to form patterned reactive sites for polymer deposition (Figure 4.2). The hexagonal array of brighter dots (UTS sites) within a darker background (OTS thin film) is shown with a $7 \times 7 \ \mu m^2$ area topography view (Figure 4.2a). The 211 UTS nanopillars shown in the $7 \times 7 \ \mu m^2$ area can

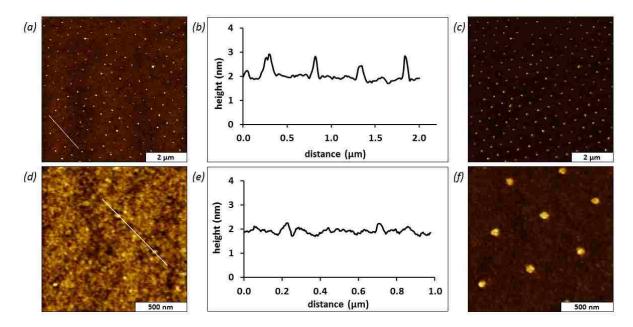


Figure 4.2 Selective backfilling of UTS into OTS nanopores. (a) $7 \times 7 \ \mu m^2$ topograph. (b) Cursor profile for the line in a. (c) Lateral force image of a. (d) Zoom-in view. (e) Cursor profile for the line in d. (f) Corresponding lateral force image of d.

scale up to ~10⁸ nanopillars per cm², which demonstrates that particle lithography is high throughput method to generate nanopatterns. The nanopillars of UTS have an average height of 1.1 ± 0.6 nm. A cursor line over four selected UTS nanopillars reveals that the height distribution range is 0.7-1.2 nm and the distance between two adjacent UTS pillars is ~ 500 nm, which was determined by the size of the removed silica mesospheres (Figure 4.2b). The chemistry difference between methyl group of OTS and vinyl group of UTS is clearly distinguishable on the lateral force image (Figure 4.2c). A $1.4 \times 1.4 \mu m^2$ topograph cannot clearly differentiate the pattern because there is no noticeable height difference between the OTS background and the UTS nanopillars (Figures 4.2d and 4.2e). However, the chemistry difference between methyl and vinyl terminal groups is more discernible in the simultaneously acquired lateral force image, as the brighter areas indicate UTS sites and darker background indicates the OTS resist (Figure 4.2f).

The 2-D chemically patterned surface served as a good foundation for further polymer deposition. This foundation was amplified at the patterned reactive sites to a 3-D pattern by thiolene click reaction between the thiol end-groups of P(NEG₃₂-*r*-NBG₁₇) and the vinyl groups of UTS (Figure 4.3). The patterned P(NEG₃₂-*r*-NBG₁₇) nanopillars are shown in the wide view topograph with average height of 8.1 ± 2.7 nm (Figure 4.3a). The periodicity and morphology of the

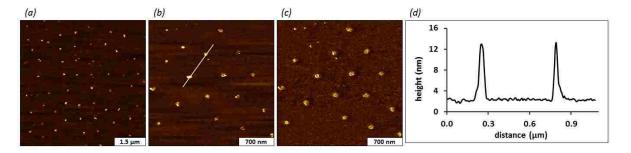


Figure 4.3 Copolypeptoids polymer nanopillars after thiol-ene click reaction. (a) $6 \times 6 \ \mu m^2$ topograph acquired by contact-mode AFM. (b) Close-up view. (c) Simultaneously acquired lateral force image of b. (d) Cursor profile for the line in b.

copolypeptoid nanopillars on surface are shown in the $2.5 \times 2.5 \ \mu\text{m}^2$ topography view (Figure 4.3b). The chemistry difference between polypeptoid nanopillars and OTS background can be clearly seen in the corresponding lateral force image (Figure 4.3c). Two selected polymer nanopillar areas (see cursor line in Figure 4.3b) have measured a height of ~11 nm and at a distance of ~540 nm (Figure 4.3d). The inhomogeneity of a single polypeptoid nanopillar site in the lateral force image indicates that there are many polymer brushes at one nanopore site with an upright orientation.

The thermo-responsiveness of the linear random copolypeptoid P(NEG₃₂-*r*-NBG₁₇) was investigated using *in situ* AFM in aqueous media after patterning of the polymer brushes on Si surface. As the temperature of the liquid media surrounding the Si substrate was ramped at 5 C increments, the height of the polypeptoid nanostructures appeared to change. The results at three selected temperatures (25 C, 45 C and 65 C) are shown in Figure 4.4 and more temperature studies are shown in Appendix C (Figure C2). The heights decrease of two particular polymer brush sites were monitored and indicated in the topographs (Figures 4.4a, c and e) and cursor profiles (Figures 4.4b, d, and f). At 25 C, the heights of the two nanostructures vary (Figure 4.4b), which is according to the original size of the nanoholes within OTS. The polymer brushes collapsed upon heating, as indicated by a nanopillar height decrease from more than 10 nm (25 C) to less than 3 nm (65 C).

The LCST behavior of the copolypeptoid was also studied with the turbidity assay using untethered copolymer in aqueous solution. The onset cloud point temperature (T_{cp}), the temperature measured at 90% transmittance, is 45 C for a solution of copolypeptoid (1 mg•mL⁻¹ in water) (Appendix Figure C3). Changes in the composition of copolypeptoids can be used to adjust the cloud point temperature within the range of 20-60 C. In aqueous solution, the unbound

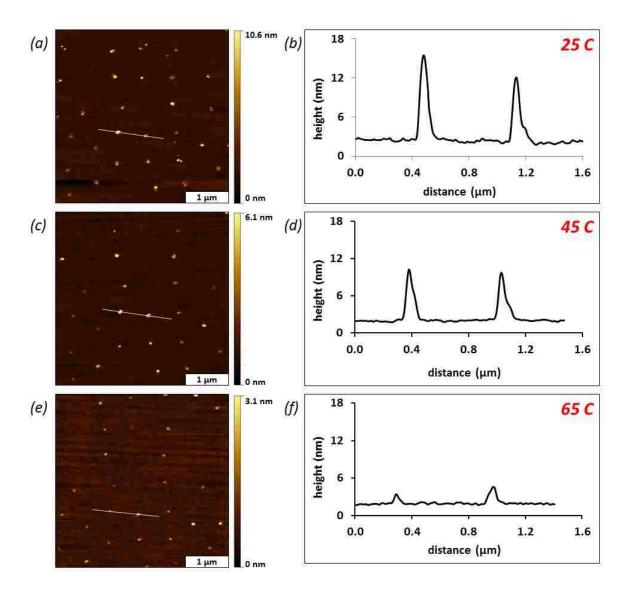


Figure 4.4 *In situ* thermo-responsive study of nanopatterned random copolypeptoids, $P(NEG_{32}-r-NBG_{17})$. All of the AFM images have scan size $4 \times 4 \mu m^2$. Two particular spots were tracked during the heating process. (a) Topograph acquired at 25 C. (b) Cursor profile for the line in a. (c) Topograph obtained at 45 C. (d) Height profile for the line in d. (e) Topography image acquired at 65 C. (f) Cursor profile for the line in g.

 $P(NEG_{32}$ -*r*-NBG₁₇) is solvated at room temperature, as evident by the 100% transmittance, and as the temperature is increased to the onset T_{cp} , the solution becomes turbid as the copolymers collapse and aggregate. This physical phenomenon (copolymer collapse/aggregation) can be clearly seen with the surface patterned copolypeptoids with *in situ* AFM imaging. A proposed mechanism for the thermo-responsive properties of copolypeptoids nanostructures is illustrated in Figure 4.5. At ambient temperature, the water soluble polymer brushes are fully extended in aqueous media due to hydrogen bonding between polymer chains and water molecules (Figure 4.5a). Upon heating, the hydrogen bonding is interrupted, resulting in the collapse of the polymer brushes, which ultimately aggregate and condense on surface to form compact structures (Figure 4.5b). The effects of heating and cooling are reversible. If the polymer dissolves in aqueous solution, upon cooling, the polymers become hydrated, disrupting the aggregates, and generating a fully extended polymer chain. If the polymer is immobilized on a surface, turning from the collapsed form to the extended form appears to be a much slower process than unbound polymer (approximately 1 h is need in our experiment).

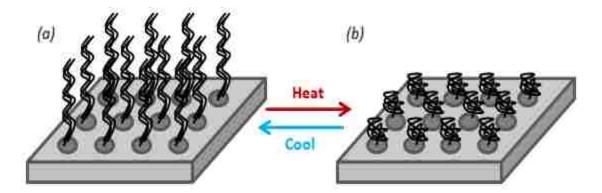


Figure 4.5. Proposed mechanism of the thermo-responsiveness of patterned copolypeptoids. (a) Free-standing polymer brushes in aqueous solution at room temperature. (b) Collapsed polymer brushes on surface at elevated temperature.

The thermo-responsiveness of eight polymer brush sites was tracked (Figure 4.6). With an increase in temperature, the heights of the eight polymer brush sites decrease. At the starting temperature (25 C), the polymer brushes have heights ranging from 8.1 nm to 16.2 nm. At the final temperature (80 C), nearly all of the polymer brush sites have height of 1-1.5 nm, which means

the length of the polymer brush in our experiment does not influence the trend of decreasing in height of the random copolypeptoid $P(NEG_{32}-r-NBG_{17})$ with increasing in temperature.

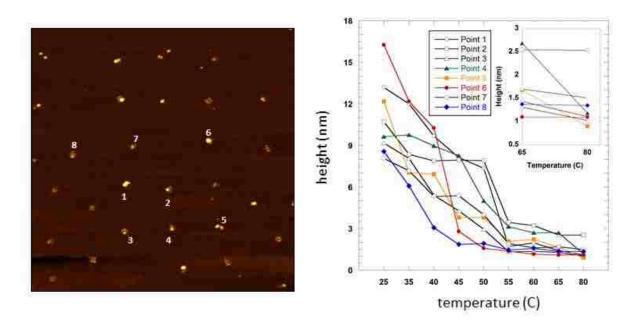


Figure 4.6 Temperature-dependent changes in height studied *in situ* with AFM. (left) Example topograph at 25 C. The heights of eight polymer brush sites were tracked. (right) Measurements for height decrease with rising temperature (C).

4.4 Conclusion

In conclusion, to the best of our knowledge, for the very first time, the thermoresponsiveness of patterned polymer brushes at the nanoscale was studied *in situ*. Thiol-ene click chemistry turned out an efficient way to attach functionalized linear polymer, in our case, the random copolypeptoid poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine₁₇)], or P(NEG₃₂-*r*-NBG₁₇), to the substrates. The surface changes at nanoscale can be sensitively detected with AFM when increasing temperature to 35 C. However, the transmittance change only can be noticed after 45 C at eh onset cloud point temperature.

CHAPTER 5. A REVIEW ON FORCE MODULATION MICROSCOPY AND THE CAPABILITY OF NANOMECHANICAL MAPPING OF SURFACE ELASTIC AND VISCOELASTIC PROPERTIES

5.1 History of Force Modulation Microscopy (FMM)

Since its invention in 1986, atomic force microscopy (AFM) has been used in a broad range of fields for surface characterizations.¹ Force modulation microscopy (FMM), one of over 50 possible modes of AFM, was invented in 1991 by Maivald and Hansma et al. to study the carbon fiber and epoxy composite.¹⁴

With FMM, local mechanical properties of a sample surface can be acquired along with topography by imposing a z axis vibration between tip-sample contact during contact-mode imaging. Dynamic response of the sample to an increased or decreased load is monitored. In the first report of FMM, variations in the local elasticity were differentiated on a composite surface at the nanoscale.¹⁴ The sample was placed on a piezoelectric translator and the AFM tip was raster scanned across the sample surface in contact-mode with constant force. At the same time, a z axis vibration of 25 nm was introduced to the sample through the z piezoelement. The frequency of the z axis vibration was tuned so that it did not interfere with the resonance frequencies of the feedback loop and minimized the coupling with the electronics. The cantilever deflection is larger on the harder regions compared with softer regions during FMM, because more pressing energy from the cantilever can be absorbed by the soft regions and more deformation was encountered by the soft regions. Clear contrast was acquired in the amplitude image and the elasticity modulus of carbon fibers and epoxy were estimated.

Due to the relative high forces (10⁻⁷-10⁻⁶ N) applied during contact-mode AFM, images of soft materials suffer from insufficient contrast and quality. The author who did the earliest work of FMM realized that: since soft materials like biological samples are usually deposited on hard substrates for AFM work, the FMM increases the potential of imaging soft materials because of

the success of characterizing carbon fiber and epoxy composite. A large variety of soft materials were studied with FMM such as polymers and proteins over the past 20 years because the great advantage of using FMM to image soft materials on hard surfaces.^{61-65, 73, 81, 208-211}

5.2 Instrument Set-up of FMM

There are four instrumental configurations for force modulation microscopy based on either tip or sample vibration in the z axis when the system is operated in contact-mode. The most common design is shown in Figure 5.1 where the sample is placed directly on top of an xyz scanner. Actuation of the z piezoelement of the scanner by applying sinusoidal voltage causes the sample to vibrate for tip displacements of a few nanometers in the z direction perpendicular to the scanning plane.^{60, 62, 77-80, 82} A modulation of the vertical sample position leads to a modulation of the force between tip and sample. This force modulation results in an indentation of the sample depending on its elasticity. The modulation frequency is chosen to be 3-4 orders of magnitude larger than the scan frequency to avoid the cutoff frequency of the feedback loop (~0.5 kHz), the resonance

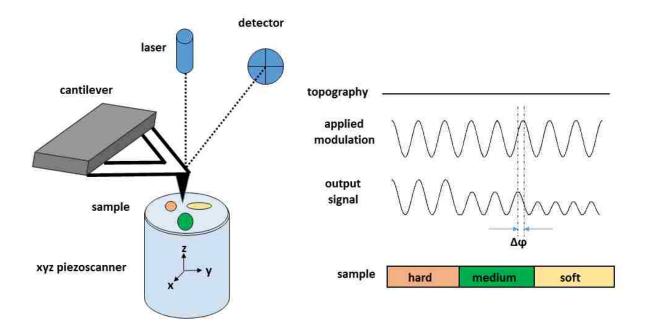


Figure 5.1 Instrument setup and operating principle of force modulation microscopy.

frequency of the piezoscanner (~8 kHz) and the cutoff frequency of the photodetector (~1 MHz).⁶² Soft probes with spring constants less than 1 N/m are usually used in FMM studies because of the possibility of plastic deformation (wear) of the polymer surface.⁸⁴ The oscillation amplitude is kept small so that the topography image will not be degraded by vibration at tip-sample contact.

A flat surface with three regions of varying elastic moduli is shown as a proof-of-concept in Figure 5.1. From the FMM topograph, a flat surface without any contrast will be resolved. Comparing to the input sinusoidal wave signal, the output signal has an amplitude change and a phase angle shift which are detected by two lock-in amplifiers and translate to FMM amplitude and FMM phase images. Careful comparisons between FMM topographs with contact-mode topographs have been made and no significant differences were found.⁸³

In the second instrument configuration for FMM, a cantilever holder equipped with bimorph piezoelements, which can actuate the tip as it is pressed against the sample, is used.^{63, 74, 83-84} The bimorph piezos can oscillate the cantilever near resonance frequency during tapping-mode and depress the tip into the sample surface during FMM.⁶³ Therefore, two modes are enabled using the same set-up.

The third way to accomplish force modulation imaging is using a magnetic field to drive the vibration of a tip or tip-holder assembly.^{85-88, 212} In Yamamoto's work, samples were mounted on a piezoelectric tube scanner, inside of which a coil for an electromagnet was fixed. A piece of samarium cobolt magnet was glued at the end of the backside of the cantilever.⁸⁵ In Pietrement's work, the solenoid was placed around the piezotube and a small spherical magnetic particle of LaNdFeB alloy was glued on the backside of the cantilever just above the tip.²¹³ Indirect magnetic modulation (IMM), invented by Li et al., is another instrument configuration for FMM.⁸⁶ The entire tip assembly, containing ferromagnetic materials, is induced to vibrate with the flux of an external AC electromagnetic field, generated by a wire coil solenoid underneath the sample plate.

The fourth design is a scan-by-tip AFM configuration, the z axis vibration is applied to the sample. Troyon and Hazotte et al. placed a transducer underneath the sample, which is a 0.5 mm thick and 8 mm round disk.⁷⁶ Lu and Garno et al. embedded a piezoactuator inside a machined polycarbonate sample stage to generate the z axis vibration by applying AC current to the piezoelement.

5.3 Advantages of FMM

Force modulation can be used for identifying and mapping differences in stiffness or elasticity, evaluating materials' homogeneities,^{85, 214} and studying variations in crystallinity,⁶ polymer phase separation, surface arrangement and distribution.^{80, 215-217} Mechanical properties of the surfaces are probed continuously over extended areas instead of at scattered individual points as in force-distance curves and load-indentation measurements.⁸³ Asif and Colton et al. combined nanoindentation and force modulation microscopy together to acquire nanoscale mechanical properties.²¹⁸⁻²¹⁹ In force-distance curve measurement, the probe is not perfectly perpendicular to the sample due to the 10-15° tilt of the cantilever. Therefore, the load has a tangential component in the direction parallel to the cantilever arm, which induces error measurements.²¹³ To overcome the scanning angle problem in FMM, Overney and Fijihira et al. added an additional piezo plate between the piezoscanner and sample so the z modulation direction can be freely adjusted within 90° by tilting the piezo plane.⁷⁸

Force modulation microscopy can also quantify information about sample surfaces such as Young's modulus and elasticity.^{75-76, 79, 213} An example of calculating the spring constant of sample surface is given here.⁷⁹ For FMM when the sample is modulating in the z axis on top of a piezotube, the cantilever deflection ΔZ_c caused by the sample modulation ΔZ_p was measured sensitively by a lock-in amplifier. Consequently, the sample is deformed by the amount

$$\Delta Z_{eff} = \Delta Z_p - \Delta Z_c \tag{Equation 5.1}$$

 ΔZ_c will be smaller on softer and larger on harder surfaces. With a cantilever having spring constant K_c and a sample spring constant K_s , the variation of the force acting on the surface is given by

$$\Delta F = K_s \left(\Delta Z_p - \Delta Z_c \right) = K_c \, \Delta Z_c \tag{Equation 5.2}$$

Rearrangement of the Equation above will result in the spring constant of the sample

$$K_s = K_c \left(\frac{\Delta Z_p}{\Delta Z_c} - 1\right)^{-1}$$
 (Equation 5.3)

This K_s value directly gives information about surface elastic properties.

To determine the Young's modulus of the sample surface, the Hertz model is used to describe the deformation of the tip-sample contact.⁷⁵ If an elastic spherical tip is in contact with a flat, elastic sample, the penetration depth d of the tip into the sample is given by

$$d = (\frac{9W^2}{16{E'}^2 R})^{1/3},$$
 (Equation 5.4)

where

$$\frac{1}{E'} = \frac{(1 - \nu_t^2)}{E_t} + \frac{(1 - \nu_s^2)}{E_s},$$
 (Equation 5.5)

W is load, R is tip radius, E is Young's modulus, v is Poison's ratio, and the subscripts t and s stand for the tip and sample. Differentiating Equation 5.4 gives the load-displacement curve as a function of applied load

$$\frac{\partial W}{\partial d} = (6E'^2 RW)^{1/3}$$
 (Equation 5.6)

If considering the static force, W_0 , to cause a static sample penetration d_s^0 , then the oscillation of the z piezo can be viewed as causing a small change, δW . to the applied static force resulting in a small change in the penetration, δd .

$$\frac{\delta W}{\delta d} = (6E'^2 R W_0)^{1/3}$$
 (Equation 5.7)

$$\delta W = k_c \, d_c \tag{Equation 5.8}$$

$$\delta d = d_s = d_b - d_c \tag{Equation 5.9}$$

$$W_0 = k_c d_c^{0} + W_a \tag{Equation 5.10}$$

where d_c is cantilever deflection, k_c is cantilever spring constant, d_s is sample penetration depth, d_b is the oscillation of the bimorph piezo, W_a is adhesion force, and the static force W_0 applied by the cantilever can be related to the mean deflection of the cantilever d_c^0 . By applying Equations 8-10 to Equation 7 a quantitative measurement of Young's modulus is made:

$$E' = [6(\frac{d_b - d_c}{k_c d_c})^3 R(k_c d_c^0 + W_a)]^{-1/2}$$
(Equation 5.11)

5.4 Studying Self-assembled Monolayers (SAMs) Using FMM

The surface elastic and viscoelastic properties of self-assembled monolayers (SAMs) are widely studied with FMM. Some FMM work in SAM systems are summarized in Table 5.1. Bi-functional surfaces of Langmuir-Blodgett (LB) film comprised of two kinds of molecules were used as samples to probe the elasticity and viscoelasticity using FMM. Most of the systems were investigated using the z piezoelement to generate the z axis vibration of the samples. Either qualitative comparison between two components' elasticities or quantitative information about the Young's modulus were acquired. Vibration amplitude of a few nanometers was used, which is much smaller than tapping-mode. The vibrational frequency was chosen to be much higher than imaging speed but avoid interference with the feedback loop. Commonly a cantilever with a small spring constant (<1 N/m) is used.

Sample	Operating system	Information acquired	Driving amplitude	Driving frequency (kHz)	Cantilever spring constant	Ref
Langmuir Blodgett film of C ₁₉ H ₃₉ COOH and C ₉ F ₁₉ C ₂ H ₄ -O- C ₂ H ₄ COOH	Sample mounted on xyz scanner	A higher Young's modulus on the hydrocarbon domains	2-5 nm	11-19	0.17 N/m	220
Langmuir Blodgett film of C ₂₁ H ₄₃ COOH and C ₉ F ₁₉ C ₂ H ₄ - O-C ₂ H ₄ COOH	Sample mounted on xyz scanner	Difference in elasticity is 0.1 GPa	1 nm	4	0.25 N/m	78
Langmuir Blodgett film of C ₂₁ H ₄₃ COOH and C ₉ F ₁₉ C ₂ H ₄ -O- C ₂ H ₄ COOH	Sample mounted on xyz scanner	Difference in elasticity is 0.1 ± 0.03 GPa	2-5 nm	11-19	0.17 N/m	215
Mixed monolayer of octadecyltrichlorosilane (OTS) and [2-(perfluorooctyl)ethyl] trichlorosilane (FOETS)	Sample mounted on xyz scanner	Crystalline OTS has a higher modulus than amorphous FOETS	0.89 nm	5	0.022 N/m	80
Patterned monolayer of alkanethiol	Nanoscope Ill	C18 surface is stiffer than C7	1-100 mV	8	0.02-0.7 N/m	221
Octadecyltriethoxysilane monolayers	Sample mounted on xyz scanner	Measurements taken in liquid more accurately reflect the viscoelasticity	1-54 nm	12-45	0.1 N/m	89
Langmuir Blodgett film of L-α dimyristoylphosphatidylcholine (DMPC) and quercetin palmitate (QP)	Nanoscope multimode	QP domains are softer		8	20-100 N/m	222
Nanostructures of actadecanthiols inlaid in decanethiol SAMs	Sample mounted on xyz scanner	$E^* = 0.014 \ln(x) + 0.859$ x: size of the nanostructures			0.1 N/m	223
Patterned triethylene glycol mono-11-mercaptoundecyl ether (EG ₃ -thiol)	Modified Asylum MFP- 3D	Young's modulus of the EG ₃ -thiol on gold is 30 GPa		20	0.7	224

Table 5.1 Examples of SAM systems using FMM as a tool to study the surfaces.

An example of using FMM to study the dynamic viscoelastic response of phase separated SAM system is shown in Figure 5.2.⁸⁰ Octadecyltrichlorosilane (OTS) and [2-(perfluorooctyl)ethyl]trichlorosilane (FOETS) (50/50, mol/mol) mixture was spread on a water surface and transferred on Si using an upward drawing technique. The silanes were hydrolyzed on the water surface and the hydroxyl groups were polymerized to form Si-O-Si bridges between silanes. After transferring to the Si substrate, the silanes bound to the Si surface covalently to form a phase separated silane monolayer of OTS and FOETS.

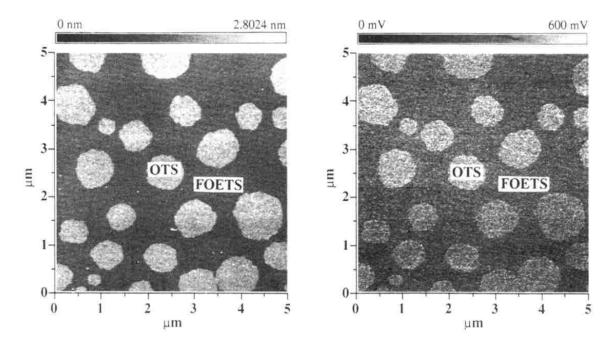


Figure 5.2 A mixed monolayer of OTS/FOETS (50/50, mol/mol) studied with FMM at frequency of 5 kHz and z axis modulation of 0.89 nm. (left) Topography and (right) elasticity images. Reprinted with permission.⁸⁰ Copyright 1994 American Chemical Society.

The sample shown in Figure 5.2 is mounted on an xyz piezoscanner. The modulation of the vertical sample position leads to an indentation of the tip against the sample depending on its viscoelasticity. The phase separated OTS and FOETS pattern can be viewed in the topography and elasticity images and were acquired using FMM at a driving frequency of 5 kHz and a vibration amplitude of 0.89 nm. Circular flat-topped OTS domains are surrounded by a flat FOETS matrix

with a height difference of 1.3 nm, which can be seen from the topography image. From the elasticity image, the bright areas correspond to the higher modulus region. Areas of OTS have bright contrast with high modulus because OTS SAM is in a crystalline state at 293 K.

In FMM amplitude and phase channels, contrast of images sometimes vary or flip with the changes of experiment conditions, such as vibration frequencies (Figure 5.3).⁸⁹ In this example, octadecyltriethoxysilane (OTE) SAM was prepared on mica. By increasing the imaging force in a $150 \times 100 \text{ nm}^2$ scan area and removing away the OTE molecules, a nanoscopic mica area inlaid in the OTE SAM was fabricated. Force modulation images were taken from 10 to 50 kHz, at 1 kHz intervals. Six representative frequencies were chosen to show the frequency-dependent property of FMM. Even though the Young's modulus for mica is 130 GPa and less than 1 GPa for OTE, the mica region should appear darker in contrast for the amplitude channel because 2-4 layers water film is on top of mica under the experimental condition (room temperature and 50% humidity) as shown in Figures 5.3b, c and f. The water molecules formed a capillary neck when the tip was scanning and dampened the tip's z axis vibration in FMM. However, a contrast flip can be seen in Figures 3a, d and e. The authors found out that at conditions where the driving frequency overlaps with the resonance of tip-mica contact, a contrast flip was observed. However, the authors operated FMM in liquid media such as 2-butanol and they found out the contrast in amplitude and phase channels are more consistent. Measurements taken in liquid media accurately reflect the viscoelasticity of samples because adhesion forces between the tip and sample are minimized.

Contrast in FMM amplitude and phase images can be dominated by factors other than simple elasticity, such as the driving frequency,²²⁵ imaging media,^{89, 226} tip-sample contact area,²²¹ amplitude of oscillation,²²⁷ and the shape and stiffness of the tip.^{72, 217} Therefore, measurements from FMM can provide surface information about heterogeneities in stiffness rather than absolute or relative values.^{84, 228} However, it is possible to operate FMM in regions that the image contrast reflect the relative elasticities of different components by tuning the experimental conditions.

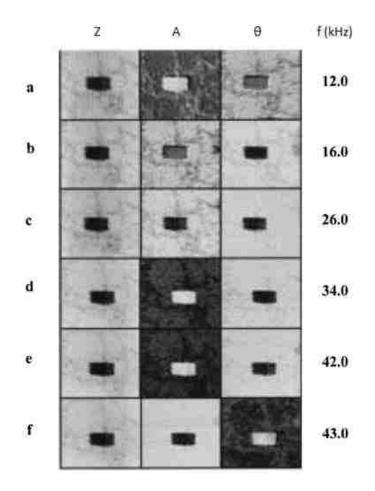


Figure 5.3 An octadecyltriethoxysilane monolayer with nanoshaved rectangular at center on mica investigated with FMM. Topography (Z), amplitude (A), and phase (θ) images from six driving frequencies were shown. The image sizes are all 500 nm² and the nanoshaved area has size 150 x 100 nm². The z axis modulation is 9 nm. Reprinted with permission.⁸⁹ Copyright 1999 American Chemical Society.

5.5 Investigating Polymeric Materials Using FMM

Polymeric composites, blends, individual chains and block copolymers were studied with

FMM and some of the work has been summarized in Table 5.2. Samples, substrates, FMM set-

ups, information acquired and experimental conditions are all discussed in detail.

Sample	Operating system	Information acquired	Driving amplitude	Driving frequency (kHz)	Cantilever spring constant	Ref
Epoxy and carbon fiber composite	Stylus bottom xyz scanner	Modulus 2.1 x 10 ¹¹ Pa for carbon fiber and 7.0 x 10 ¹⁰ Pa for epoxy	25 nm	5	0.6 N/m	14
Polymeric diamino-diethyl-ene glycol-pentacosadiynoic acid (DPDA) monolayer	Sample mounted on xyz scanner	Polymeric DPDA film is softer than the substrate	6 nm	15.6	0.064 N/m	77
LB film of Poly(diamino-diethylene glycol-pentacosadiynoic)	Magnetic actuated z axis tip vibration	Spring constant of the film is 6 N/m	0.3 nm	5-44		229
Individual polystyrene molecules	Sample mounted on xyz scanner	Thiol-terminated polystyrene is softer than the dodecanethiol	0.1 nm	10	0.1 N/m	79
Phase separated polystyrene and poly(vinyl methyl ether) (PS/PVME) blend film	Sample mounted on xyz scanner	Mechanical tan $\delta = 0.25$ for PVME and 0.1 for PS	1.2 mV	5	0.022 N/m	80
Toughened polypropylene/(ethylene propylene) (PP/EP) copolymer resins	Sample mounted on xyz scanner	PP matrix is much stiffer than the EP modulus	1 nm	2	10 N/m	61
Polystyrene-polyethyleneoxide (PS/PEO) blend surfaces	Sample mounted on xyz scanner	PEO is 7% softer than PS	1 nm	5	0.75 N/m	62
Poly(dimethylsiloxane) (PDMS) film	Function generator	Viscosity 430 ± 40 cP	1 nm	10	40 N/m	230
Industrial polymer blends	Cantilever holder was equipped with bimorph piezo	Polypropylene is stiffer than ethylene propylene; Exxpro 90-10 is stiffer than Budene 1207	0.1-1.2 V	11	0.4-1 N/m	63
Polymer blend of poly-2- vinylpyridin (P2VP) and polytertbutylmethacrylate (PtBMA)	High frequency piezoelectric transducer	The adhesive force of PtBMA is larger than P2VP	3 V	233.1	0.75 N/m	231

Table 5.2 Examples of polymeric systems using FMM as a tool to study the surfaces.

A composite material consisting of carbon fibers embedded in an epoxy matrix was investigated using FMM (Figure 5.4).⁶ A bimorph piezo set up, which was introduced earlier, was used. The height variation of the surface is 0-150 nm for the topography image, and 0-1 nm for the amplitude image. The contrast of the topography image is not as sharp as the amplitude image. More pronounced contrast between the hard carbon fiber (brighter: higher amplitude) and soft epoxy matrix (darker: lower amplitude) is shown in the oscillation amplitude image.

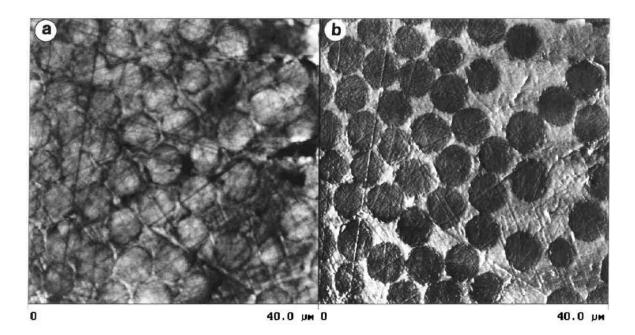


Figure 5.4 Composite materials of carbon fibers embedded in epoxy matrix imaged with FMM. (a) Topography and (b) amplitude images. Reprinted with permission.⁶ Copyright 1997 Annual Reviews.

Free-standing gels containing entangled fibrils, which were formed by block copolymer poly(*N*-methyl glycine)₁₀₀-*b*-poly(*N*-decyl glycine)₁₀ or *c*-PNMG₁₀₀-*b*-PNDG₁₀ were investigated using FMM (Figure 5.5).²³² The height range is 0-157 nm in the topography image which is the reason that large polymer aggregates can be seen but not the fibrillar structures in the background. However, using FMM at driving frequency of 163.8 kHz, both polymer aggregate and fibrils are clearly resolved in the amplitude and phase channels. Since the fibers are crystalline-like materials

and tend to be harder than the surrounding gel, the fibers appear brighter in contrast in the amplitude channel.

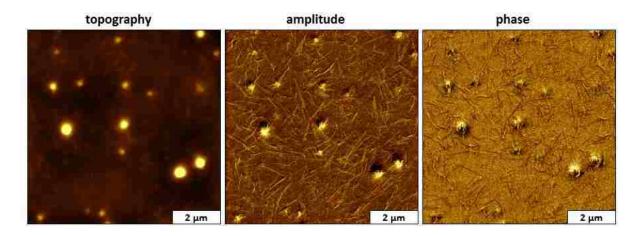


Figure 5.5 Polymeric gel containing fibers viewed from topography, amplitude and phase images acquired with FMM at vibration frequency of 163.8 kHz.

Another interesting FMM study on polymer blends with polystyrene (PS: molecular weight is 19600 g/mol) and polyethyleneoxide (PEO: molecular weight is 100000g/mol) is shown in Figure 5.6. The solution of PS and PEO blended with 1:1 weight ratio in benzene was spin coated on mica. The sample was annealed at 90 C for 24 h before FMM measurement. During FMM, the z axis oscillation of the sample was achieved by applying sinusoidal voltage to the vertical piezo scanner on which the sample was fixed. The imaging force for phase separated PS-PEO was 6 nN in the surrounding area and 50 nN in the square shown in Figure 5.6. Scratches are noticed on both PS and PEO areas when imaging force was increased to 50 nN. Crystallized PEO should exhibit spiral or layered structures, which means taller structures in Figure 5.6a are PS and shorter features are PEO. The corrugation amplitude is 15 nm for PS and 15-30 nm for PEO. Outside of the central area in Figure 5.6b, the response of the cantilever is found to be about 7% smaller on PEO than on PS, which means PEO is softer. In the central area, a large elasticity change is noticed that PEO

regions become stiffer after experiencing a large-force scanning and the difference in cantilever response decreased to 1-2 %.

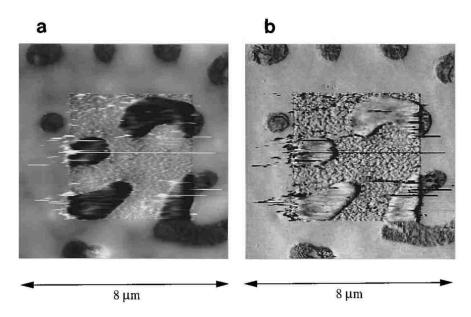


Figure 5.6 Phase separated PS-PEO blend film studied with FMM with imaging force 6 nN and modulation frequency of 5 kHz. The central area of 5 μ m² was scanned with force of 50 nN. (a) Topography and (b) elasticity images. Reprinted with permission.⁶² Copyright 1995 IEEE Xplore.

Molecular chain imaging of poly(vinylidenefluoride-trifluoroethylene) crystal under an amorphous layer was the first report on high resolution imaging of polymer lamella structures using FMM by Kimura and Matsushige et al.²³³ A 6 nm x 5 nm scan with lamella stripes spaced at 0.53 nm in the FMM amplitude image was achieved. One year later, the same researchers published work on submolecular resolution viscoelastic imaging of a poly(p-toluene-sulfonate) single crystal using FMM.

5.6 Probing Biological and Inorganic Samples Using FMM

Biological samples such as protein-lipid aggregates,⁶⁵ phase separated lipid monolayers,²³⁴ bovine serum albumen,²³⁵ wood cells and fibroblasts,⁶⁶⁻⁶⁸ magnetotactic bacteria, and live human platelets,^{69, 236} were studied with FMM. Inorganic samples such as porous silicon,⁷⁰ ion tracks,²³⁷

nickel-based superalloy,⁷⁶ hybrid materials,²³⁸⁻²³⁹ and Gd_2O_3 or SiO₂ optical thin films,⁷¹ were also probed with FMM to acquire the surface elastic and viscoelastic information.

An example of structural organization of surfactant protein B containing lipid monolayers imaged with FMM is shown in Figure 5.7. Surfactant protein B with a molecular weight of 18 kDa and saturated phospholipids dipalmitoylphosphatidylcholine and dipalmitoylphosphatidylglycerol (4:1 with protein content 1 mol%) were transferred on mica. For FMM, a contact-mode probe with a spring constant of 0.12 N/m was used. The probe was oscillated by a biomorph piezo at 9 kHz and indented slightly into the sample. The z scale for the topography image of Figure 5.7 is 25 nm and 2 nm for the amplitude image. The amplitude image gives much sharper contrast as compared to the topograph. The author claimed that the darker contrast in the amplitude channel indicated materials with higher elastic modulus, which is a stiffer material. The lighter contrast area in Figure 5.7b are protein-enriched phase which has lower Young's modulus.

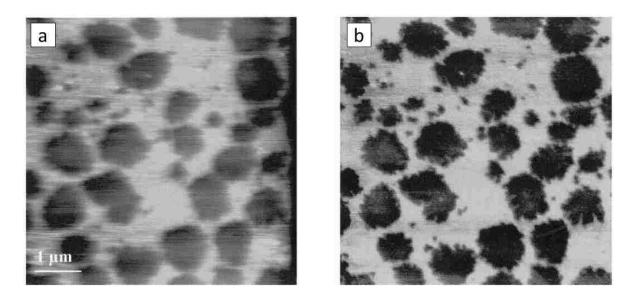


Figure 5.7 Surfactant protein B containing lipid monolayers imaged with FMM. (a) Topography image with the z scale of 25 nm. (b) Amplitude image with the z scale of 2 nm. Reprinted with permission.⁶⁵ Copyright 2000 Elsevier.

5.7 Conclusions

Force modulation microscopy is a powerful mode of AFM to acquire surface topography and mechanical information simultaneously. Four FMM set-ups which were commonly used in the literature were discussed in this review. Visualized AFM images containing the elastic and viscoelastic differences about surface features can be shown in FMM amplitude and phase images. Quantitative information such as Young's modulus and elasticity can be calculated based on amplitude channel of FMM. Application of FMM in self-assembled monolayer systems and polymeric materials were summarized and discussed. The FMM mode was also applied in inorganic and biological system to study the mechanical property of samples. Factors such as the vibrational frequency, imaging media, and the shape and stiffness of the tip may influence the contrast in FMM amplitude and phase images. However, it is possible to operate FMM in regions that the image contrast reflects the relative elasticities of different components by tuning the experimental conditions.

CHAPTER 6. SAMPLE STAGE DESIGNED FOR FORCE MODULATION MICROSCOPY USING A TIP-MOUNTED AFM SCANNER

6.1 Introduction

Force modulation microscopy (FMM) can be used to identify and map differences in stiffness or elasticity,^{79, 84} evaluate the composition of materials,⁸⁵ and to study variations in crystallinity,⁶ polymer phase separation, surface arrangement and distribution.^{80, 215-217} Materials that have been studied with FMM include protein-lipid aggregates,⁶⁵ patterned self-assembled monolayers (SAMs),⁶⁰ as well as polymer blends and resins.⁶¹⁻⁶⁴ Molecularly resolved images of polymer crystals have been acquired with FMM.^{233, 240} Quantitative measurements can be evaluated using FMM for the Young's modulus and the elasticity of samples. ^{75-76, 79, 213}

For FMM mode the scanner is operated in contact-mode while the sample stage is driven to vibrate. The AFM probe is scanned in continuous contact with the surface as the sample is driven to vibrate at selected frequency and amplitude. Information of the topography, elastic response and surface adhesion can be acquired concurrently. There are two instrument configurations that have been used to accomplish FMM imaging, either the sample or tip can be driven to vibrate with pressure applied at the area of tip-sample contact. Most commonly FMM has been done using an instrument configuration with the sample placed directly on top of an xyz scanner. Actuation of the z piezoelement causes the sample to vibrate for tip displacements of a few nm in the z-direction.^{62, 77-80} Studies have been done using a cantilever holder equipped with bimorph piezoelements to accomplish force modulation, which can actuate the tip as it is pressed against the sample.^{63, 84} A magnetic field has been used to drive the vibration of a tip or tip-holder assembly to accomplish force modulation imaging. ^{16, 85, 87} The driving frequency,²²⁵ imaging media,^{89, 226} tip-sample contact area,²²¹ amplitude of oscillation,²²⁷ and the shape and stiffness of the tip^{72, 217} influence the resolution of FMM amplitude and phase images. A systematic study of the factors which influence the contrast in FMM was previously reported by Jourdan, et al. for nanopatterns inscribed within a film of organosilane.⁸⁹

With the wide implementation of commercial scanning probe instruments designed to have the tip mounted on the piezotube scanner, it would be practical to develop a sample stage to facilitate sample modulation for FMM experiments. An accessory stage for FMM studies was constructed with machined polycarbonate using an insulated coaxial cable connection to apply current to an actuator element. The operation of the sample stage was evaluated by characterizing three test samples with nanoscale dimensions. Test structures of nanoholes within a film of octadecyltrichlorosiloxane (OTS) provide two distinct surface regions as the simplest platform for FMM studies. Ring-shaped nanostructures prepared on Si(111) with 2-[methoxy (polyethyleneoxy)propyl]trichlorosilane (PEG-silane) provide three domains for evaluating FMM data. Finally, a complex sample consisting of a cyclic gel polymer of poly(*N*-methyl glycine)₁₀₀*b*-poly(*N*-decyl glycine)₁₀ containing fibrils was selected for FMM studies. Experiments were accomplished in ambient conditions using conventional soft cantilevers.

6.2 Experimental Section

6.2.1 Materials and Reagents

Anhydrous toluene from Sigma-Aldrich (St. Louis, MO) was used as a solvent. Ethanol used for cleaning samples was acquired from Pharmco-AAPER (Boucherville, Quebec). Octadecyltrichlorosilane (OTS) and 2-[methoxy(polyethyleneoxy)propyl]trichlorosilane (PEG-silane) were purchased from Gelest (Morrisville, PA) and used without further purification. Pieces $(5 \times 7 \text{ mm})$ of polished Si(111) doped with boron (Ted Pella, Inc., Redding, CA) were used as substrates for preparing nanopatterned films. Substrates were cleaned by immersion in piranha solution for 1.5 h. Piranha solution is a mixture of sulfuric acid (Sigma-Aldrich) and hydrogen peroxide (30%, Sigma-Aldrich) at a ratio of 3:1 (v/v). This solution is highly corrosive and should

be handled with caution. Silicon substrates were then rinsed copiously with water (Milli-Q, Millipore, Bedford, MA) and dried with argon. Monodisperse polystyrene (496 \pm 8.1 nm) and silica (0.49 \pm 0.02 µm) solutions were purchased from Duke Scientific (Palo Alto, CA). The mesospheres were washed with deionized water by centrifugation to remove contaminants such as charge stabilizers or surfactants. To prepare the cyclic gel sample for FMM, the polymer sample was dissolved in methanol at 1% wt and formed a flow gel after 30 min. A drop of the flow gel (10 µL) was deposited on a piece of freshly cleaved mica(0001), then dried in air before imaging with FMM-AFM.

6.2.2 Atomic Force Microscopy

A Keysight model 5500 scanning probe microscope (SPM) equipped with a multipurpose scanner was used for AFM characterizations (Keysight Technologies, Tempe, AZ). The scanner has interchangeable nosecones for selected imaging modes. An empty plastic nosecone assembly (the contact-mode nosecone) without metal components was used for force modulation experiments. Silicon nitride cantilevers with an average force constant of 0.1 N m⁻¹ were used for FMM-AFM imaging (MSCT, Bruker, Camarillo, CA). Picoview v1.12 software was used for data acquisition. Images were processed with Gwyddion (version 2.31) open software supported with Czech Metrology Institute, which is freely available online.²⁴¹

6.3 Results and Discussion

6.3.1 Design of the FMM Sample Stage

The sample stage was made with machined polycarbonate with a shape that was designed for operation with a Keysight 5500 SPM. A photograph of the stage is shown in Figure 6.1, indicating the location of the piezoactuator and the BNC cable connection. The essential component of the FMM stage is the piezoactuator element (dimensions: $1 \times 1 \times 0.2$ cm), which enables a z-displacement of 2.2 µm in the range of 0-100 V input and has an axial resonance frequency of 600 kHz (Physik Instrumente, Auburn, MA). For FMM studies, the voltages applied to the piezoactuator ranged from 0.05-0.5 V. The black and red wires connect the piezoactuator to the BNC cable which enables input of an AC signal to the stage to induce the vibration of the piezoelement. With the Keysight 5500 instrument, a MAC box was used as an AC source by connecting with the AAC output channel. There are three round flat magnets to attach the sample stage to the scanner housing. Two alignment tracks were machined into the polycarbonate sample holder for translating the sample stage in the x and y direction. A small magnet was embedded within the center of the stage above the piezoactuator to attach samples. Samples for FMM studies can either be magnetically clamped, taped or glued to the center of the stage. Further technical details of the physical dimensions of the stage are provided in Appendix Figure D1.

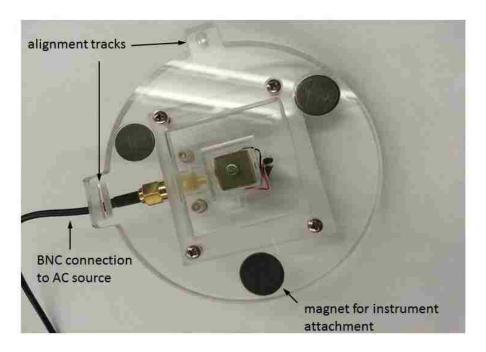


Figure 6.1 Photograph of the polycarbonate FMM sample stage. The square piece at the center of the stage is the piezoactuator, with a small circular magnet placed at the center for attaching samples.

6.3.2 Characterization of Nanopatterns within an OTS Film using the FMM Sample Stage.

A test sample of OTS nanopatterns formed on Si(111) was used to evaluate the operation and sensitivity of the FMM sample stage. Details of the procedure for preparing samples using particle lithography with OTS were previously reported and are presented in Appendix Figure D2.²²⁸ Experiments were designed to test the effect of turning the drive on or off as well as evaluating changes in images for selected frequencies. Simultaneously acquired channels for topography, amplitude, and phase are shown in Figure 6.2 for the sample of OTS nanopores. The

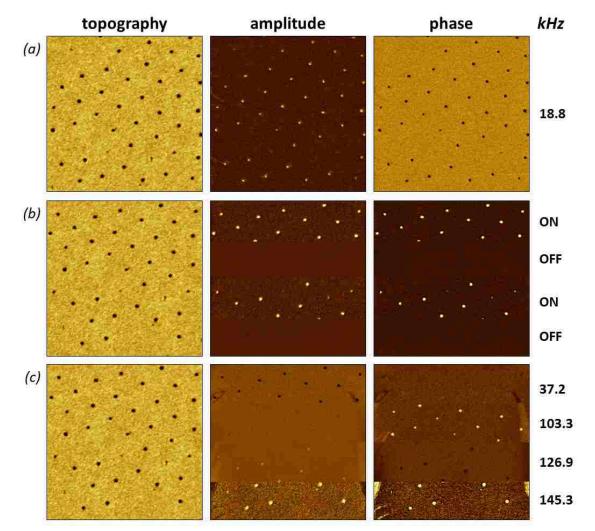


Figure 6.2 Sample of nanopores within a thin film of OTS characterized with the FMM sample stage. (a) Images acquired at frequency of 18.8 kHz. (b) Image acquired with the drive turned on or off at a frequency of 145.3 kHz. (c) Dynamic FMM study with ramping of the frequency parameters during a single scan. The size of the images are $3 \times 3 \mu m^2$.

same area was scanned using selected parameters for sample modulation. A hexagonal arrangement of nanopores is visible in the topography frames, where the dark spots are areas of uncovered substrate and the brighter areas are the matrix film of OTS. The distance between adjacent nanopores measures 490 ± 44 nm. The depth and diameter of the nanopores measured 2.0 \pm 0.2 nm and 110 \pm 10 nm respectively. Changes in the bright or dark contrast of the areas of the nanopores are reversed for the amplitude versus phase channels in Figure 6.2a, when imaging at frequency of 18.8 kHz. The bright or dark regions are highly sensitive to the driving frequency of the sample stage. The phase images do not necessarily correlate with hardness of the samples. When the drive is turned off, no features are distinguishable in amplitude and phase images as demonstrated in Figure 6.2b. Note that by changing the frequency to 145.3 kHz the harder regions of the substrate have bright contrast in both the amplitude and phase channels. In a dynamic FMM study, the results of selectively ramping the frequency are displayed in Figure 6.2c without interruption of data acquisition during a scan. The changes in color contrast for amplitude frames can be interpreted by conducting a frequency sweep experiment, an example spectrum is shown in Figure 6.3. The areas of the nanopores reveal exposed silicon substrate which is harder compared with the surrounding film of OTS, thus greater amplitude or bright contrast is expected for nanopore areas. However, the results shown in Figure 6.2c exhibit a reversal in contrast depending sensitively on the frequency that was selected.

Clear differences in color contrast between areas of the nanopores and the matrix OTS film are evident in the amplitude and phase images, however using these results to interpret the hardness or softness of the areas can be complicated. For this example, the larger resonance peaks at 18.8 and 145.3 kHz gave the predicted amplitude response showing bright dots for the locations

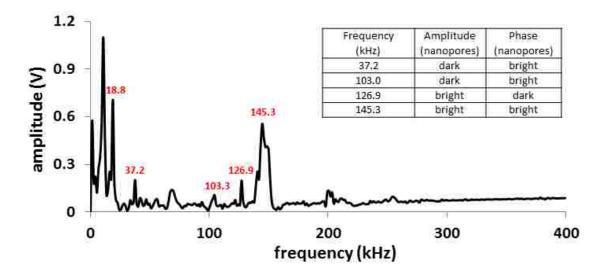


Figure 6.3 Frequency sweep experiment with the sample of OTS nanopores.

of the nanopores. The frequency or amplitude chosen for driving the tip vibration, determine whether the tip is operated in the attractive or repulsive regime for FMM imaging.

A further test of the FMM stage was accomplished by zooming-in to acquire surface views with higher magnification (Figure 6.4). At this size scale the irregular outline of a single nanopore becomes apparent. The texture of the OTS film can be resolved, showing a clustered morphology. This example demonstrates the high resolution capabilities that can be achieved with the home-constructed FMM sample stage.

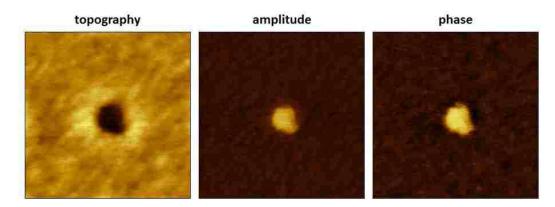


Figure 6.4 Details of a single nanopore revealed with FMM. Images were acquired at 145.3 kHz for an area measuring $0.4 \times 0.4 \ \mu\text{m}^2$.

6.3.3 FMM Characterization of Nanorings of PEG-silane

Nanopatterns of PEG-silane rings prepared on Si(111) were characterized with FMM-AFM as shown in Figure 6.5. For this example, there are three distinct regions visible in the images. There are uncovered areas of the substrate at the centers of the nanorings, the regions of the nanorings are multilayers of PEG-silane, and the areas in between the rings are a relatively homogeneous and compact film of PEG-silane. The sample was prepared using particle lithography combined with heated vapor deposition, as previously described.²⁴² (Details for sample preparation are also provided in Appendix Figure D3.) The areas of the taller nanorings have

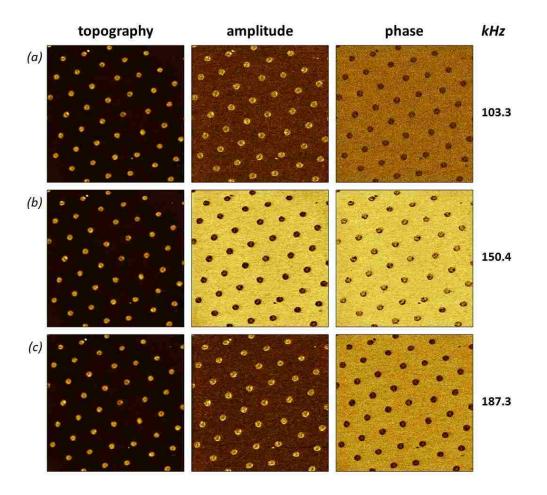


Figure 6.5 Images of PEG-silane nanorings acquired with the FMM sample stage at driving frequencies of (a) 103.3 kHz, (b) 150.4 kHz and (c) 187.3 kHz. Images are $3 \times 3 \ \mu m^2$ scan sizes.

brighter contrast in the topography images indicating the areas of a multilayer of PEG-silane. The thickness of the nanorings measures 5.9 ± 1.3 nm (Appendix Figure D4). The areas between the nanorings contain a film of PEG-silane. Areas of exposed substrate are located at the very center of the nanorings. The distance between nanorings measured 490 ± 45 nm, which corresponds to the diameter of the latex mesospheres (500 nm) that were used as a surface mask for particle lithography. The same area was scanned with selected frequencies to evaluate the changes for images shown in amplitude and phase channels (Figure 6.5).

Three frequencies (103.3, 150.4, and 187.3 kHz) were selected for Figure 6.5 to study the changes for PEG-silane nanorings with FMM-AFM. We would predict that areas of the nanorings with a multilayer film of PEG-silane would have the darkest color for the amplitude frames, as shown in the center amplitude image acquired at a driving frequency of 150.4 kHz. The nanoring structure is made of multilayers of PEG-silane which is a softer material compared with the surrounding matrix areas and the center of the rings, which leads to a smaller amplitude for tip indentation. The center amplitude image acquired at 150.4 kHz also sensitively reveals a tiny bright spot at the center of each nanoring for the region of exposed hard substrate. The images in Figures 6.5a and c disclose brighter contrast for the PEG-silane nanorings, which does not follow our prediction. Examples of contrast reversal have been previously reported for nanopatterns within an organosilane film.⁸⁹ The contrast observed for amplitude and phase images depends sensitively on the modulation parameters of frequency and amplitude and indicate the viscoelasticity of the sample.

The frequency spectrum acquired for the sample is presented in Figure 6.6, which shows the highest amplitude response of the selected frequencies occurs at 150.4 kHz. As with the example of Figure 6.2, the optimal frequency for FMM imaging are at the resonance peaks with a higher amplitude response. Brighter contrast for the nanorings was observed for the amplitude channel in Figures 6.5a and c, suggesting that the selected frequencies of 103.3 and 187.3 kHz were not optimal parameters for resolving differences in elasticity. In these examples, the edge effects and surface adhesion predominate tip-sample interactions rather than differences in hardness. In the phase channels for all three frequencies viewed in Figure 6.6, dark rings and lighter background can be clearly resolved to indicate the relative differences in viscoelasticity between the nanorings and surrounding matrix film of PEG-silane.

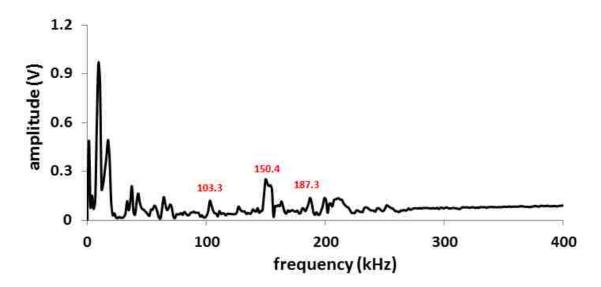


Figure 6.6 Frequency sweep acquired with FMM for the sample of PEG-silane nanorings.

6.3.4 Characterization of a Cyclic Gel Sample with FMM

A block copolymer poly(*N*-methyl glycine)₁₀₀-*b*-poly(*N*-decyl glycine)₁₀, or *c*-PNMG₁₀₀*b*-PNDG₁₀ can form free-standing gels at 5-10 wt% in methanol at room temperature.²³² The gel system contains entangled fibrillar structures that are difficult to resolve with conventional topography images. Synthesis and characterization of the cyclic gel sample was previously reported using tapping-mode AFM.²³² The gel sample is more complex than the previous examples of nanopatterns, it contains both large aggregates and small-embedded fibrils within the gel system. Topography, amplitude and phase channels obtained with FMM at four selected frequencies are shown in Figure 6.7. The same area of the sample was scanned ($8 \times 8 \ \mu m^2$) with changes of the frequency parameter. For the topography frames the details of the small microfibrils within the sample cannot be clearly resolved, however the phase and amplitude images sensitively detect the fine details of the fibril shapes and locations.

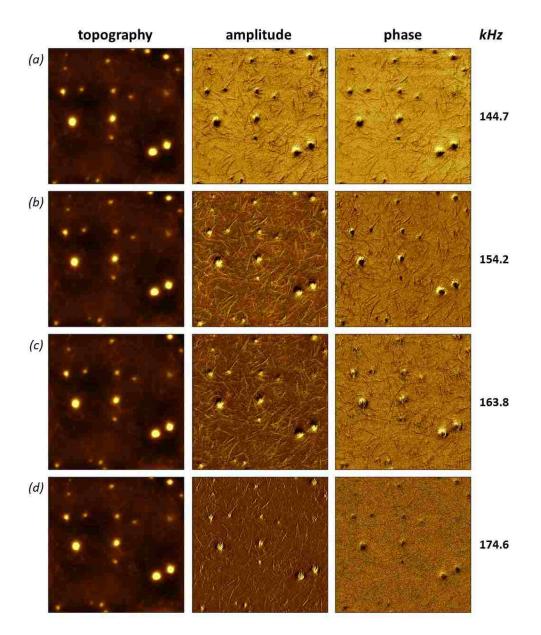


Figure 6.7 Images of the cyclic gel sample obtained with FMM at driving frequencies of (a) 144.7, (b) 154.2, (c) 163.8, and (d) 174.6 kHz. The frames are $8 \times 8 \ \mu m^2$ scans.

The fibrils are harder materials compared with the surrounding gels, therefore larger amplitude or bright contrast is expected for the fibrils as revealed in the amplitude frames of Figures 6.7b-d. Contrast reversal is shown in Figure 6.7a, where the fibrils are darker in color for the amplitude frame. The phase images of Figures 6.7a-c have excellent resolution, revealing exquisite details of the fibril morphology. However at a frequency of 174.6 (Figure 6.7d) the locations of the fibrils are not distinguishable in the phase image. These results suggest that for tuning the optimized parameters for FMM experiments selected for the amplitude channel are not necessarily the same frequency chosen for optimizing the phase images. The frequency sweep when imaging the cyclic gel sample is shown in Figure 6.8. The poorest resolution found at frequency of 174.6 kHz correlates with the smallest amplitude response. At this frequency the

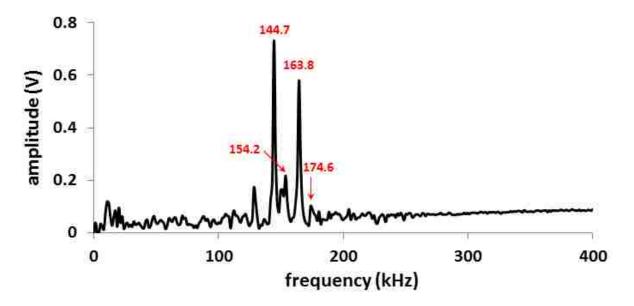


Figure 6.8 Frequency spectrum acquired with the FMM sample stage for the cyclic gel sample (*c*-PNMG₁₀₀-*b*-PNDG₁₀).

vibration amplitude is not sufficient to fully reveal differences in elastic response. However, for the other three frequencies tested with FMM, sufficient energy is supplied to acquire high resolution images for both phase and amplitude channels. Both the driving frequency and the amplitude of the resonance peak determine the resolution of the FMM amplitude and phase channels. Weaker resonance peaks were shown to display a contrast reversal for elastic response. For the sample of OTS nanopores and the nanorings of PEG-silane, strong resonance peaks were found at frequencies below 25 kHz. The voltages applied to the piezoactuator of the stage were 0.4 V for the OTS nanopores and 0.5 V for PEG-silane nanorings. For the nanopatterned surfaces of OTS and PEG-silane the overall z scale measured less than 10 nm, while the cyclic gel sample had taller features of 160 nm (Appendix Figure D5). For the complicated system of the cyclic gel sample, which has larger aggregates along with micron-sized fibrils embedded in the gel system, stronger resonance peaks were detected in the frequency range of 120-180 kHz using 0.05 V applied to the piezoactuator.

6.4 Conclusions

Excellent resolution can be achieved when using the home-constructed FMM sample stage with a tip-mounted scanner, even for complex surfaces or multi-component samples. The FMM stage is suitable for imaging samples in ambient conditions and exhibited high resolution when experimental parameters were optimized. Interpretation of FMM amplitude frames is complicated for acquiring quantitative measurements of elastic response, the parameters for driving frequency and amplitude require optimization. Knowledge of the sample composition is critical for correctly interpreting information from amplitude images. Future studies will incorporate a liquid cell for the design of the FMM stage to enable FMM characterizations in liquids. Machined glass components will be used for constructing a sample stage to enable studies in solvents.

CHAPTER 7: DIRECT COMPARISON OF SAMPLE ACTUATION VERSUS TIP VIBRATION CONFIGURATION FOR FORCE MODULATION AFM

7.1 Introduction

Force modulation microscopy (FMM) was invented in 1991 and has since been used by researchers in many fields.^{14, 77, 79-80, 82, 215, 220, 235} This mode of atomic force microscopy (AFM) is used to measure the dynamic response of the sample while applying pressure to the surface during contact-mode imaging, providing elasticity and viscoelasticity measurements of the sample.⁸¹ The most common instrument set up is to mount the sample on a piezoelectric xyz scanner and apply a sinusoidal voltage to the vertical piezoceramic material, which will cause the sample to vibrate in the z direction.^{62, 77-81} Another common setup for FMM is to use a cantilever holder equipped with bimorph piezo.^{63, 83-84} The bimorph piezo oscillates the cantilever near its resonance frequency during tapping and slightly presses the tip into the sample during force modulation. Therefore, tapping-mode and force modulation images can be acquired using this design. Mechanical vibration is not the only way to modulate the tip or sample for FMM. In some cases, a solenoid is placed around the scanner tube, where the sample is attached, to generate an oscillating magnetic field. A magnetically coated cantilever or a small spherical magnetic particle glued to the back of the cantilever can be indirectly modulated by the oscillation of the magnetic field.^{85, 87-88, 213}

Force modulation microscopy is able to acquire topographical information along with the mechanical properties (elasticity and viscoelasticity) of samples at the same time.⁶ It has great applications in a variety of fields, especially soft materials such as polymers and biological systems.^{63, 236} Polymeric systems such as toughened polypropylene resins,⁶¹ polystyrene-polyethyleneoxide and polyvinyl chloride-polycarbonate blends^{62, 64} have been probed with FMM for viscoelastic information.^{209, 230} Biological systems such as magnetotactic bacteria,⁶⁹ human platelets,⁶⁹ living fibroblasts⁶⁷⁻⁶⁸ have been investigated for elastic properties using FMM.⁶⁵⁻⁶⁶

Other systems such as hybrid materials,²³⁸⁻²³⁹ patterned or phase separated self-assembled monolayers,^{60, 216} Gd₂O₃ or SiO₂ optical thin films,⁷¹ have also been studied with FMM.^{70, 237}

Our group has developed two methods for investigating the mechanical properties of samples. We have recently designed a sample stage capable of sample modulated FMM. Several samples have been evaluated to test the abilities of this stage. This polycarbonate sample stage can be easily reshaped to fit other models of AFM. Indirect magnetic modulation (IMM), which invented in our group earlier, is an alternative way to do force modulation microscopy by indirectly modulating the nosecone assembly.¹⁶ The soft, nonmagnetic cantilever is driven to vibrate with the motion of the nosecone containing ferromagnetic materials. The nosecone is induced to vibrate with the flux of an external electromagnetic field, which is generated by the solenoid beneath the MAC-mode sample stage. The goal of this study is to use nanoring patterns of 4-(chloromethyl)phenyltrichlorosilane (CMPS) as a test platform to compare FMM using the newlydesigned sample stage and IMM using the MAC-mode stage. The organosilane, CMPS, is highly reactive to itself and easily forms multilayers on surfaces. The multilayers provide soft surfaces suitable for force modulation studies. In addition, four regions (CMPS monolayer, multilayers and hard surfaces) are formed by patterning CMPS with particle lithography, which makes this sample a good candidate for elasticity studies on surfaces. Additionally, the influence of driving frequency and vibration amplitude on FMM and IMM imaging are systematically studied in this Chapter for the very first time.

7.2 Experiment Section

7.2.1 Materials and Reagents

Single-side polished Si(111) doped with boron (Ted Pella, Inc., Redding, CA) was used as substrates. Monodisperse latex mesoparticles $(496 \pm 8.1 \text{ nm})$ were purchased from Duke Scientific (Palo Alto, CA). Nanopatterns were fabricated using 4-(chloromethyl)phenyltrichlorosilane

(Gelest, Morrisville, PA) without further purification. Toluene, sulfuric acid, and hydrogen peroxide (30%) were obtained from Sigma-Aldrich (St. Louis, MO). Ethanol was used to clean the substrate, which was purchased from Pharmco-AAPER (Boucherville, Quebec).

7.2.2 Atomic Force Microscopy

A Keysight 5500 SPM (Keysight Technologies, Tempe, AZ) was used for FMM and IMM studies. The scanner can incorporate interchangeable nosecones for selected imaging modes. A contact-mode nosecone assembly without metal components was used for the FMM study. An AAC nosecone, which has two metal pins, was used for the IMM study. Picoview v1.12 software was used for data acquisition. Images were processed with Gwyddion (version 2.31) open software supported with Czech Metrology Institute, which is freely available online.²⁴¹ A nonmagnetic silicon nitride probe with force constant of 0.1 N m⁻¹ was used for FMM and IMM imaging (MSCT, Bruker, Camarillo, CA).

7.2.3 Preparation of CMPS Nanorings

The Si(111) substrates were immersed in piranha solution for 2 h to remove organic contaminants. Piranha solution is a mixture of sulfuric acid and hydrogen peroxide at a ratio of 3:1 (v/v). This solution is highly corrosive and should be handled carefully. Substrates were then rinsed with copious of water (Milli-Q, Millipore, Bedford, MA) and dried with argon. The mesospheres were washed three times with deionized water to remove charge stabilizers and surfactants. Immediately after drying the substrate, 10 μ L of the latex mesosphere suspension was deposited. The sample was dried in air for 4 h to produce surface masks. Next, the sample was placed in a sealed cup containing 300 μ L of neat CMPS silane. The cup was placed in an oven at 70 C for 18 h. The CMPS silane was vaporized to react with Si substrate where the mesospheres do not contact the substrate. After cooling, the sample was rinsed with water and toluene. To

remove the mesoparticles, the substrate was sonicated for 15 min in ethanol and toluene successively. The sample was dried under argon before characterization with FMM and IMM. 7.2.4 Characterization of CMPS Nanorings with Stage-driven FMM.

The polycarbonate sample stage is designed for a Keysight 5500 AFM and can be manufactured for other SPM models. A 1 cm \times 1 cm \times 0.2 cm piezoactuator (Physik Instrumente, Auburn, MA) is embedded inside the sample stage and has a maximum displacement of 2.2 µm in the input range of 0-100 V. The outside AC source, which is the MAC box, can input an AC signal to the stage via a BNC cable connection; this signal induces the z-axis vibration of the piezoelement. As shown in Figure 7.1a of the FMM logo, only the center part of the stage (1.4 cm \times 1.4 cm square area) vibrates during FMM. The driving frequency and vibration amplitude can be tuned based on the frequency spectra.

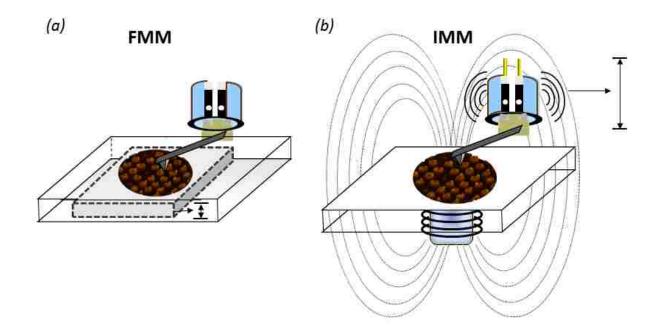


Figure 7.1 Comparison of the instrumental configuration of (a) stage-driven force modulation microscopy (FMM) and (b) tip-driven indirect magnetic modulation (IMM).

7.2.5 Characterization of CMPS Nanorings with Tip-driven IMM

The invention of IMM mode was introduced by our group previously.¹⁶ The entire tip holder assembly is indirectly modulated through the flux of an external ac electromagnetic field generated with a wire coil solenoid located underneath the sample stage Figure 7.1b (IMM logo). The metal pins inside the nosecone are vibrating in the magnetic field to indirectly vibrate the AFM tip.

Both stage-driven FMM and tip driven IMM are operated in contact-mode. Height (topography channel), elasticity (amplitude channel), and viscosity/viscoelasticity (phase channel) information can be acquired at the same time. Tips with a low spring constant (< 1 N m⁻¹) are suggested for use with both methods.

7.3 Results

7.3.1 Nanorings of CMPS Studied with FMM and IMM with and without Sample/Tip Modulation

The shape and hexagonal pattern of CMPS nanorings on a silicon surface prepared by particle lithography combined with chemical vapor deposition can be viewed in Figure 7.2. The periodicity of the CMPS nanopatterns is ~500 nm, which is determined by the diameter of the latex mesospheres used to fabricate the patterned sample. The shapes of the nanorings are not identical due to a variation in the volume of water at the meniscus of the mesospheres which affects the polymerization reaction of CMP. Brighter contrast in the topograph corresponds to the polymerized CMPS nanorings, while the darker background consists of a CMPS monolayer or nanopillars in between the nanorings. Individual dark points can be viewed in the amplitude image in the areas between nanorings, which is CMPS nanopillars (several layers of CMPS). The centers of the nanorings are the bare silicon substrates, which are the lowest point on the surface.

When manually turning on and off the vibration of the sample stage during FMM imaging, clear contrast changes can be seen from the FMM amplitude and phase channels (Figure 7.2a). Topographs will not be influenced by the vibration of the stage since the AFM is operated in contact-mode and the tip keeps in constant contact with sample surface.⁸³ There is no signal present in the amplitude channel when the sample stage vibration is turned off. Some contrast can be seen in the phase channel when the vibration is turned off which is attributed to edge effects. Therefore, without the vibration of the sample stage, AFM system is operated in contact-mode; while with the vibration of the stage, the system is operated in force modulation so that there will be contrast in the amplitude and phase channel. The vibration frequency of the stage is on the order of hundreds of kilohertz, which is much faster than the feedback loop. Thus, topographical information can be isolated from the local differences in the sample's elasticity.

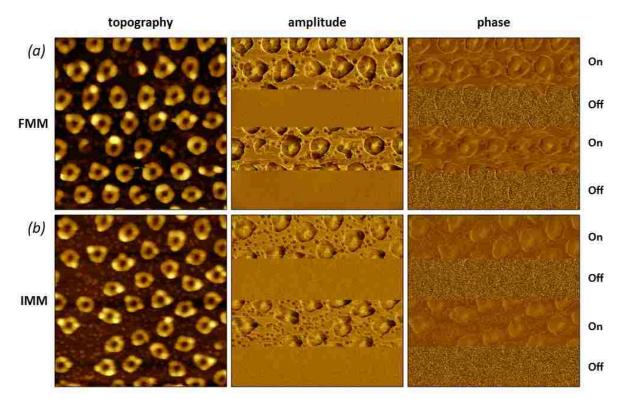


Figure 7.2 Force modulation imaging of (a) sample shaking vs. (b) tip shaking with the field turning on and off. The selected "on" frequencies for FMM and IMM are 16.3 kHz and 37.6 kHz, respectively. Image sizes are $3 \times 3 \ \mu m^2$.

Polymerization of the organosilane on the sample surface occurs due to water forming a meniscus at the base of the mesospheres. This meniscus and the volume of water it contains is necessary to initiate the polymerization reaction and leads to the nanoring formations of CMPS that were observed. In the spaces between the nanorings, individual nanopillars formed because the existence of clustered water molecules on surface. The rest of the area between nanorings is a single monolayer of CMPS. The result is a sample that contains several differing elastic regions to be compared by stage-driven FMM and tip-driven IMM. The harder the surface is, the larger the amplitude AFM tip response will be. Therefore, the lighter contrast of the center of the nanorings should be seen in the amplitude channel, as shown in the amplitude image which was acquired at a frequency of 16.3 kHz. Even though the color contrast in the phase image is not distinct, the difference of the viscoelasticity between the nanorings, the center of the nanorings and the surrounding is still obvious.

To compare with stage-driven FMM, the nanoring patterns on Si(111) surface were characterized by tip-driven IMM with the magnetic field on and off (Figure 7.2b). The nanorings and nanopillars can be seen in the topography image. Switching the magnetic field between on and off does not influence the topography image, while no contrast can be obtained when the magnetic field is off in the amplitude and phase image. The distinct edges can be seen when turning off the field in the amplitude and phase images. The selected driving frequency of 37.6 kHz was used when acquiring Figure 7.2b. The dark contrast of the nanorings and nanopillars along with the light contrast of the center of the nanorings is apparent in the amplitude image. This corresponds well with the elasticity difference of the materials on surface, since softer materials should have lower amplitude. The color contrast of the phase image when field is on is not distinct, but nanoring structures are still visible.

Nanorings of CMPS studied with stage-driven FMM and tip-driven IMM with and without sample/tip modulation have similar results. High resolution AFM images with elasticity information can be acquired for both methods when same amount of voltage was applied to the system (0.8 V).

7.3.2 Nanorings of CMPS Studied with FMM at Selected Driving Frequencies

The frequency-dependence of the tip response to the CMPS nanorings is shown in Figure 7.3. The same area was scanned five times at selected driving frequencies (Figures 7.3a-e). The color scales for the topography frames of Figures 7.3a-e for the height differences remain the same regardless the frequency used. Light contrast of the nanorings and dark contrast of the centers of nanorings in the amplitude frame can be seen at driving frequencies of 35.2, 95.6, and 152.4 kHz (Figures 7.3c-e). Dark nanorings and light center can be viewed in the amplitude channel at a frequency of 16.3 kHz (Figure 7.3b). The contrast at a frequency of 11.5 kHz is not distinct, but the shape still can be seen with clear edges of the nanorings (Figure 7.3a). The viscoelasticity difference of the sample surface can be viewed clearly in the phase frames of Figures 7.3a-c and e, but not d. A clear contrast difference between center of the nanoring (bare substrate) and the surrounding area (CMPS monolayer) can be seen from amplitude channels b, c, and d, and phase channels a, b, c, and e.

In the amplitude channel, the harder material should have a lighter contrast. This means that a frequency of 16.3 kHz is the most representative frequency to show the mechanical differences of the CMPS nanoring sample.

7.3.3 Nanorings of CMPS Studied with IMM at Selected Driving Frequencies

Five driving frequencies of 37.6, 54.6, 76.8, 144.1 and 163.1 kHz were selected based upon the frequency sweep, which will be shown later, to investigate the frequency-dependence of this sample using tip-driven IMM. The same area was scanned five times at selected frequencies as

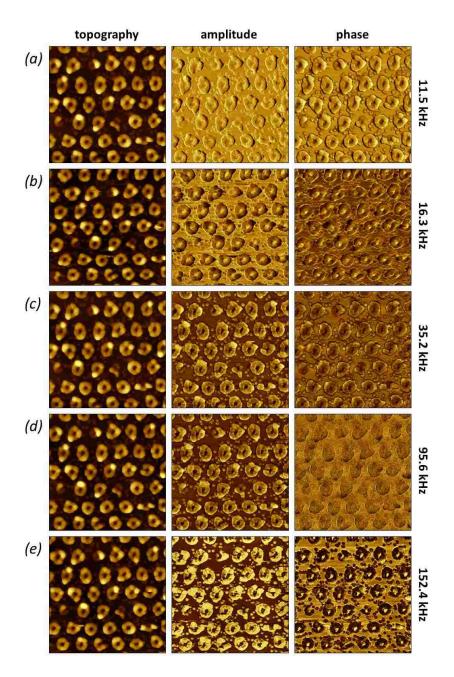


Figure 7.3 Nanorings of CMPS imaged with FMM at selected driving frequencies. Image sizes are 3 \times 3 μm^2 .

shown in Figure 7.4. The color contrast of the topography frames (Figures 7.4a-e) stays the same regardless of the driving frequency used. In the amplitude frames, dark contrast of the nanorings and light contrast at the center of the nanorings can be viewed at frequencies of 37.6 and 76.8 kHz, with the opposite effect at frequencies of 54.6 and 163.1 kHz. Therefore, frequencies of 37.6 and

76.8 kHz were chosen to study the mechanical properties of this sample using IMM with this probe. The interesting edge effect can be seen at frequency of 144.1 kHz in the amplitude channel. In the

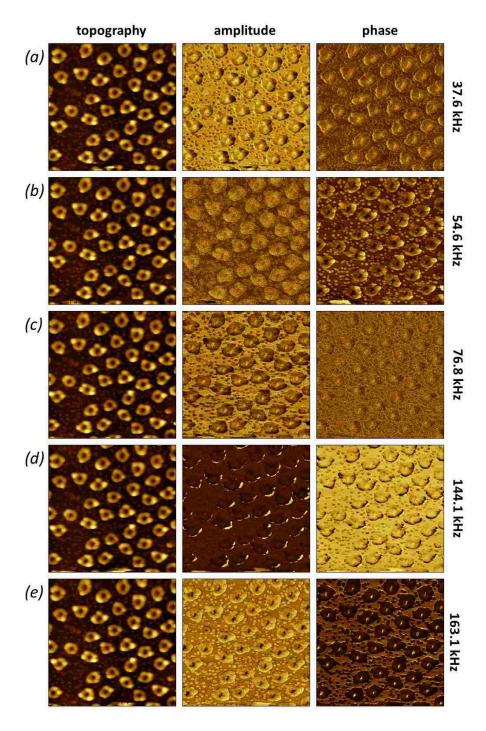


Figure 7.4 Nanorings of CMPS imaged with IMM at selected driving frequencies. Image sizes are 3 x 3 μ m².

phase images, more clear contrast can be viewed at frequencies of 54.6 and 163.1 kHz than the other three. The difference of the center of the nanoring and the surrounding area can be viewed from amplitude images of a, c, e and phase images of b and e.

7.3.4 High Resolution Stage-driven FMM and Tip-driven IMM Images of CMPS Nanorings

Three individual CMPS nanorings were imaged with FMM in the $800 \times 800 \text{ nm}^2$ scan area (Figure 7.5a). The morphology of the nanorings can be seen from the topograph, while the small nanopillars cannot be resolved clearly due to the significant difference in heights between the nanopillars and the nanorings. The high resolution amplitude frame gives more details about this sample surface. First, each nanoring structure is not homogeneous. Instead, slight height and morphology differences can be seen along a single nanoring. Second, the individual CMPS nanopillars beside the nanorings can be seen clearly. Third, light contrast in the center of the nanoring and dark contrast of the nanorings proves that the multilayer of CMPS nanoring is the softest area on the surface and the center of the nanoring is the hardest. The viscoelasticity difference of the nanoring, and the nanopillars is shown by the cursor profile (white line in the topograph). The CMPS nanoring is 24.2 nm tall, which corresponds to more than 30 layers of the CMPS silane. The center of the nanoring is 1.8 nm lower than the surrounding area, which suggests there is a monolayer or double layer in the areas between the nanorings.

Three individual CMPS nanorings are viewed in the $800 \times 800 \text{ nm}^2$ area acquired with tipdriven IMM (Figure 7.5b) in comparison with stage-driven FMM. The shape of the nanorings and the nanopillars in the surrounding area can be seen from the topograph. The center of the nanoring has a darker color contrast because it is the bare silicon substrate, which is the lowest point on surface. The morphology of each individual nanoring is not homogeneous which is determined by the local difference of the silane reaction. The amplitude frame does not give a clear elasticity difference of the features on surface compared with FMM images. The nanorings and the nanopillars do have a slightly darker contrast than the center of the nanoring and the surrounding area, which indicates a softer nature of the material. However, the difference is not as distinct as zoom-in images of FMM. The difference in viscoelasticity between nanorings and nanopillars, with center of the nanoring and the surrounding area are clearly viewed in the phase frame. However, some dark edge effects can be seen in this phase frame beside the features, which cannot be seen from the zoom-in images of FMM. The CMPS nanoring is 33.4 nm tall. The center of the nanoring is 2.5 nm deeper than the surrounding area, which indicates there are CMPS silanes binding on the silicon substrate in the areas between the nanorings during the vapor deposition step.

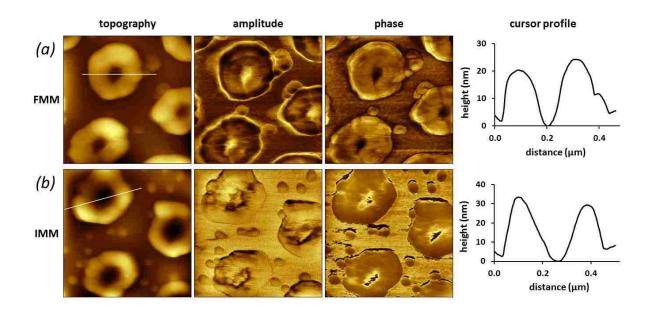


Figure 7.5 Close-up view of three CMPS nanorings $(800 \times 800 \text{ nm}^2)$ scanned by (a) FMM and (b) IMM at frequencies of 14.5 kHz and 155.2 kHz, respectively, with corresponding cursor profiles.

7.3.5 Frequency Sweeps of FMM at Selected Regions of the Sample Surface

Four regions have been selected to conduct a frequency scan to gather information about tip-sample interactions as a function of induced vibrational frequency. Four regions are labeled in Figure 7.6a as: 1) CMPS nanorings (multilayers of CMPS), 2) the center of the nanoring (bare

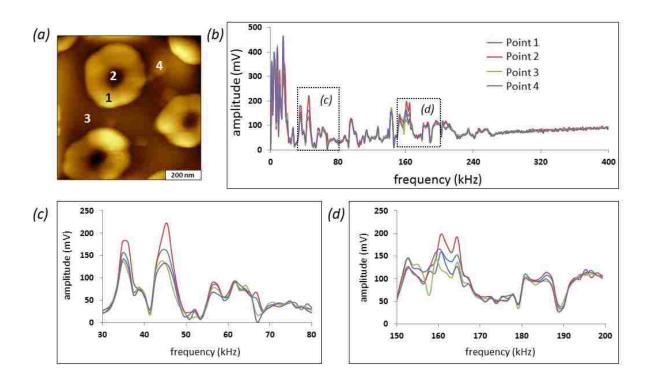


Figure 7.6 Frequency-dependent study with stage-driven FMM at selected regions of the sample surface. (a) Topograph view with four regions labeled, (b) full spectrum of the frequency sweep and two zoom-in spectra of (c) and (d).

silicon substrate), 3) areas between nanorings (monolayer of CMPS), and 4) CMPS nanopillars (couple layers). The AFM tip was placed on the four regions to acquire the frequency sweeps. The reflection of the local mechanical differences of the four points is shown in the amplitude-frequency plot of Figure 7.6. The frequency sweeps were acquired when the sample stage vibration was on. In the frequency range of 0-400 kHz, most areas of the four frequency spectra are overlapping except in the range between 30-80 kHz and around 160 kHz as shown in the two zoom-in frequency sweeps (Figures 7.6c and d). The resonance peaks from the frequency sweeps

come from the natural resonance of the piezoactuator embedded in the stage, the tip-holder assembly, and the vibration of the sample. This is why most of them are overlapping between the four frequency sweeps. At the frequency between 30-80 kHz and around 160 kHz, there is a slightly frequency shift and an amplitude difference between the four points measured. The amplitude of point 2 is the largest within the four spectrum because point 2 is the stiffest region of the four. The differences between the four frequency sweeps is due to the local elasticity differences of the sample surface as it interacts with the tip. When the sample stage is vibrating, the interaction difference is amplified and shown in the frequency sweeps.

7.3.6 Frequency Sweeps of IMM at Selected Regions of the Sample Surface

To compare with the FMM study, four similar regions were chosen to conduct the frequency scans on. Four regions are labeled in Figure 7.7a as the same way as Figure 7.6a: 1) CMPS nanorings, 2) the center of the nanoring, 3) areas between nanorings, and 4) CMPS nanopillars. The AFM tip was placed on the four regions separately to acquire frequency plots. The tip-sample interactions of the four regions are shown in the amplitude-frequency plot of Figure 7.7b. In the frequency range of 0-400 kHz, similar to FMM, most areas of the four frequency spectra are overlapping except around the frequency of 160 kHz as shown in the large-view plot (Figure 7.7b) and the zoom-in frequency sweep (Figure 7.7d). In the selected region of frequency 30-90 kHz (Figure 7.7c), the spectrum overlapping can be clearly seen. The resonance peaks from the frequency sweeps are coming from the natural resonance of the tip-holder assembly, the metal pins in the nosecone and the AFM probe. At frequency around 160 kHz, there is a clear frequency shift within the four regions measured. The differences between the four frequency sweeps around 160 kHz is due to the difference of the material's local elasticity so that the AFM tip dampened differently. When the AFM tip is vibrating along with the nosecone in the flux of magnetic field, the interaction difference is amplified and shown in the frequency sweeps. The amplitude of point

1 is the largest between the four at frequency ~160 kHz, not point 2 in FMM. To our understanding, point 2 should have largest amplitude since it is the stiffest region within the four. Therefore, we

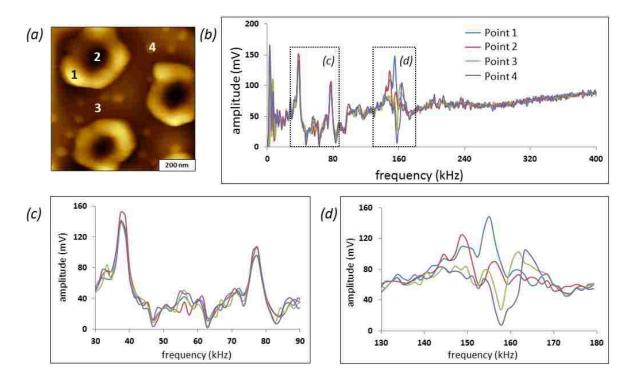


Figure 7.7 Frequency-dependent study with tip-driven IMM at selected regions of the sample surface. (A) Topograph view with four regions labeled, (B) full spectrum of the frequency sweep and two zoom-in spectra of C and D.

think stage-driven FMM is a more reliable way to test the mechanical differences on surface compared with tip-driven IMM.

7.3.7 Dynamic Stage-driven FMM and Tip-driven IMM Studies

A dynamic FMM study has been done by successfully changing the driving frequency without interruption of the data acquisition (Figure 7.8a). The dynamic study has no influence on the topography image, but distinct color changes can be seen in the amplitude and phase frames, especially when changing the frequency from 11.5 to 16.3 kHz and 95.6 to 152.4 kHz. The contrast

at frequency of 16.3 kHz is not as clear as in Figure 7.3, which is because the color magnitude change during imaging processing for the five frequencies in one single AFM image.

A dynamic study of the CMPS nanorings sample using IMM is shown in Figure 7.8b. Frequency was changed without the interruption of data acquisition. The changing of the frequency

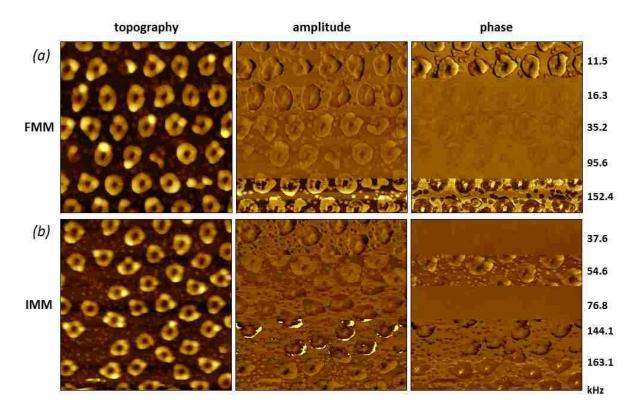


Figure 7.8 Dynamic (a) stage-driven FMM and (b) tip-driven IMM study of CMPS nanorings by incrementally changing the driving frequency during a single scan. Image sizes are $3 \times 3 \mu m^2$.

has no influence on the topography image, while clear edges can be viewed at the point when frequency changed in the amplitude and phase frames. Again, due the dynamic nature of this study, there is a decrease in contrast quality in both the amplitude and phase images. Dynamic FMM and IMM studies are efficient ways to find out best frequencies for force modulation microscopy. 7.3.8 Side-by-side Comparison of FMM and IMM at the Same Driving Frequencies.

Comparison of FMM and IMM at fourteen frequencies was done, with three sets of data displayed in Figure 7.9 while the other eleven are shown in the Appendix E as individual figures. Topography, amplitude and phase frames are all displayed separately. Frequencies of 16.3, 40.1, and 143.5 kHz were chosen to show the frequency-dependent property of this sample in Figure 7.9. The exact same AFM tip was used to acquire AFM images of both FMM and IMM at the fourteen selected frequencies. The difference in the shape of the nanorings between FMM images and IMM images is because different areas of the sample surface were scanned. The exact same area on sample surface cannot be imaged for both IMM and FMM because two sample stages are required for each method. In general, for amplitude and phase frames, FMM has a more distinct color contrast when compared with IMM (Figure 7.9). Nanorings of CMPS are softer than the background; therefore, darker contrast of the nanorings in the amplitude channel is expected. Within the three selected driving frequencies, the results from frequencies of 16.3 and 143.5 kHz of FMM are reasonable (amplitude frames), while none of them in IMM are corresponding with theoretical expectations. For the phase images, the frequency of 40.1 kHz for FMM gives the best contrast to show the difference in the viscoelasticity of components on the sample surface.

The frequency sweeps for the side-by-side comparison of stage-driven FMM and tip-driven IMM are shown in Figure 7.10. The same amount of voltage (0.5 V) was applied to the newlydesigned force modulation sample stage for FMM and MAC-mode sample stage for IMM. Smaller resonance peaks can be seen from Figure 7.10 for IMM frequency sweep. This is because in FMM, the voltage is directly applied to the force modulation sample stage to generate the vibration of the piezoactuator; while in IMM, the ac current was applied to the solenoid underneath the MAC-mode sample stage to generate an external electromagnetic field to indirectly modulate the nosecone assembly. A series of frequencies listed in the plot were used to acquire the FMM and IMM images. The reason to display FMM and IMM images of frequencies at 16.3, 40.1, and 143.5 kHz in Figure 7.9 is because: resonance peaks shown up at 16.3 kHz for both method; no resonance

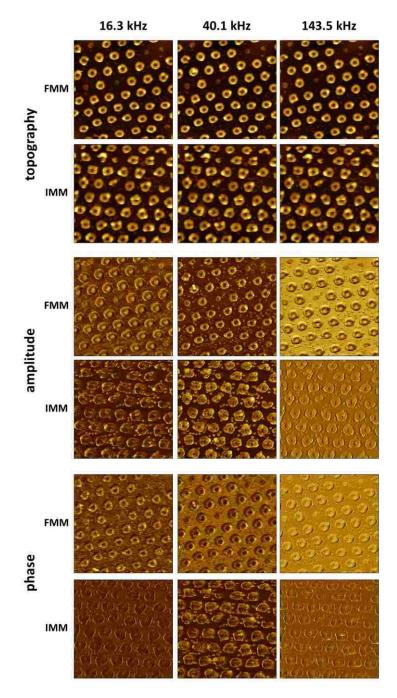


Figure 7.9 Comparison of stage-driven FMM and tip-driven IMM: (top) topography, (middle) amplitude, and (bottom) phase, of CMPS nanorings at matching driving frequencies. Image sizes are $3 \times 3 \ \mu\text{m}^2$. Images were obtained and compared at frequencies of 16.3 kHz, 40.1 kHz, and 143.5 kHz.

peaks shown up at 40.1 kHz; only resonance peak shown up for FMM at 143.5 kHz. There is not necessary to acquire force modulation images at frequencies of resonance peak areas since at frequency of 40.1 kHz clear contrast still show up.

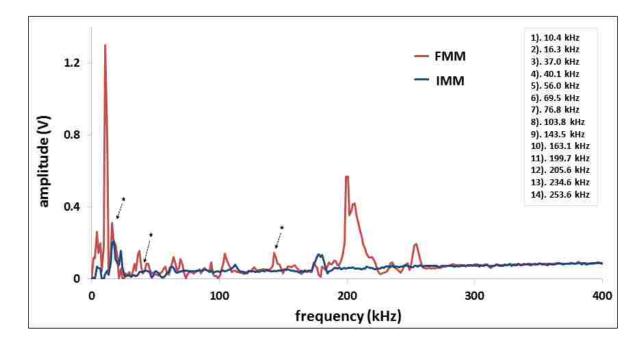


Figure 7.10 Overlay of frequency spectra obtained with (red) stage-driven FMM and (blue) tipdriven IMM. Stars indicate frequencies from Figure 7.9 that were used to compare the two types of modulation.

7.4 Discussion

To compare the difference of two force modulation methods, FMM and IMM, the exact same AFM tip was used from Figure 7.2 to Figure 7.8, another tip for Figures 7.9-7.10 and all figures shown in supporting information. The reason we have to switch to the second tip is because tip broadening was noticed after multiple uses of the previous tip. However, both of the AFM tips are the same type and have the same spring constant of 0.1 N m^{-1} .

To acquire frequency sweeps for both FMM and IMM at selected regions of the surface to compare the mechanical responses, close-up views were required so that the tip can be accurately placed on distinct surface features. Multiple regions have been used to acquire the frequency sweeps to prove that the differences in the elasticity of the sample cause a frequency shift around 160 kHz for this sample. Based on the previous discussion in this paper, more reliable information can be obtained from the frequency sweep from stage-driven FMM.

By inputting same amount of voltage to the sample stage, more amplitude response in FMM than IMM was detected. This is because the current applied to the FMM piezoactuator is directly vibrating the sample stage, while the current for IMM stage is to generate magnetic field, then the nosecone is vibrated by the flux of the magnetic field. Higher resolution images were acquired using FMM than IMM (Figures 7.5). More surface details can be found from this zoom-in view of FMM than IMM. Based on our experience, it is easier to acquire data using FMM because IMM is more sensitive to the environment noise and vibration and usually takes longer time for the AFM to stabilize.

7.5 Conclusion

Nanoring patterns of 4-(chloromethyl)phenyltrichlorosilane (CMPS) were prepared with particle lithography combined with silane vapor deposition. This test platform is a good candidate for force modulation studies because of the range of elasticities present in the features of the surface. The influences of modulation and non-modulation, driving frequency, and vibrational response have been studied for both force modulation microscopy (FMM) and indirect magnetic modulation (IMM). The images of FMM and IMM at the exact same driving frequencies have been compared and discussed. The method of FMM using the newly-designed sample stage proved to be an easier, more efficient way to obtain high resolution AFM images that can be used to compare local mechanical differences on a sample.

CHAPTER 8. CONCLUSIONS AND FUTURE PROSPECTUS

Nanopores within a film of organosilane were used as miniature containers for depositing initiators for surface initiated polymerization. Nanostructures of poly(*N*-allyl glycine) were generated on Si(111) using particle lithography. Experimental results were characterized step-by-step with high resolution AFM. The nanostructured surface platform has potential application in smart coatings, drug delivery, and bioseparations due to the biocompatibility, backbone degradability and thermal processability of the polymer. For future studies, other polymeric materials can be patterned on surfaces using the protocols developed in this dissertation.

Thermo-responsive copolypeptoids were pre-synthesized and attached onto patterned organosilanes using thiol-ene click reaction. The polymer has a narrower distribution of heights when using the "graft to" approach. Phase transitions of the polymer nanostructures were investigated using *in situ* AFM at the molecular level. Experimental results were compared with a turbidity assay for the aqueous solution of the bulk material. Higher sensitivity was observed with the *in situ* AFM study of the shrinkage and entanglement of the polymer chain. The phase transition of other systems can be studied with this approach for future studies. Further investigations of this platform in biosensor applications should be promising because of the excellent biocompatibility of polypeptoids.

Force modulation microscopy (FMM) is commonly used to acquire mechanical properties of samples concurrent with topographic information. The FMM mode is particularly useful for studying polymer samples and organic thin films. A sample stage for FMM constructed of machined polycarbonate was designed and tested. The designed FMM sample stage is compatible with a tip-mounted AFM configuration. A piezoactuator was mounted within the sample stage to drive the vibration of the sample in the z-direction. Information of elastic or viscoelastic properties of samples can be acquired with FMM. Three samples with increasing complexity were selected to test the capabilities of the FMM stage design. High resolution AFM results concurrent with sample elasticity can be acquired. Future studies will incorporate a liquid cell for the design of the FMM stage to enable characterizations in liquids. Machined glass components will be used for constructing a sample stage to enable studies in solvents.

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APPENDIX A: PROCEDURE FOR FORCE MODULATION MICROSCOPY (FMM) USING NEWLY-DESIGNED SAMPLE STAGE

Hardware set-up

For FMM operation, connect cables as shown in Figure A1. Connect a BNC cable to the **AUX** of the head electronic box to the **PHASE** input of MAC/AC controller. Connect a second BNC cable from the **AMPLITUDE** output of MAC/AC controller to the **AUX IN** of the PicoSPM II controller. Connect a third BNC cable from the **AAC** output to the BNC cable of the force modulation sample stage.

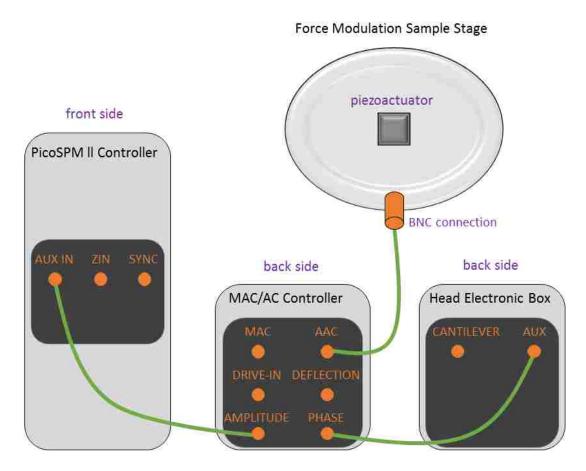


Figure A1 Cable connections for FMM imaging

1. Use the plain nosecone (contact-mode nosecone) with the Keysight 5500 AFM multipurpose scanner for FMM imaging.

- 2. Connect three cables between the PicoSPM II controller, MAC/AC controller, head electronic box, and the FMM sample stage as shown in Figure A1.
- Use silicon nitride cantilevers (MSCT, Bruker Probes) with force constants of 0.01-0.6 N/m for FMM imaging.
- 4. Put a magnet at the center of the FMM sample stage, then use double sided tape to glue the sample on the magnet. Do not directly glue the sample on the sample stage.
- Install the FMM sample stage and the scanner for FMM operation. Adjust the position of laser and photodiode signal so that **Deflection** at -1 and **LFM** at 0 on the head electronic box.

Software set-up

- Launch the Picoview v1.12 software. Under main menu, select contact mode parameters for Keysight 5500 AFM multipurpose scanner.
- Create six channels on the second monitor including trace and retrace of topography, Aux BNC (amplitude) and HEB Aux (phase) on the top/bottom row. Choose channels on the top row to represent trace data and those on the bottom row to display retrace data.
- Open the AFM AC Mode Tune window and set up the frequency range between 0 to 600 kHz.
- 4. Enter 0 for the **Force Setpoint** and then start to approach.
- 5. Under Control menu, select "advanced", choose "AC mode", Select AAC option in the drive control window. Enable the **Drive On** and start the drive on percentage at 5%.

Frequency sweep

- After the tip engages the surface, click on the Manual Tune button in the AC Tune window to acquire a frequency spectrum with the vibration of the force modulation sample stage.
- Adjust the Drive On % until significant, detectable peaks are observed for the frequency sweep (peak amplitude around 1 V). Save the frequency sweep as a *.txt file.
- 3. Choose the resonance frequencies in the frequency sweep by moving the red dash line on top of the resonance peak maximum.

FMM imaging

- Start to acquire FMM images and adjust the Integral (I) Gain, the Proportional (P) Gain, the driving frequency and the Force Setpoint to tune the images.
- 2. During experiments, compare images and spectra with and without the field activated. Turn the field on and off by enabling or disenabling the **Drive On**.
- 3. Try different resonance frequencies in the sweep and compare the FMM results.

APPENDIX B: PROCEDURE FOR TEMPERATURE STUDIES USING THE HEATING STAGE WITH KEYSIGHT 5500 OR 5420

For AFM temperature studies, connect the cables from **HEATER OUT** and **INPUT A** of the back side of the heating stage controller to the heating sample stage as shown in Figure B1. Plug in the power cord. Then put the sample on the heating stage and insert to either Keysight 5500 or 5420. Caution: when using double-sided tape to glue the samples make sure the tape will not melt or influence the study at the temperature range you plan to use. If operating the temperature study in liquid medium, check the boiling point of the solvent and the temperature range you plan to use.

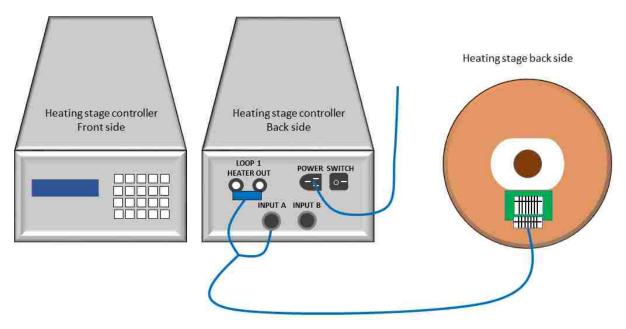


Figure B1 Cable connections for the operation of the heating stage

After cable connections, choose the right settings in the front side of the heating stage controller:

- 1. Click set point and choose the temperature you want to heat the sample to.
- 2. Click **heater range** and choose between **high**, **low** or **off**. This determines how fast the heating speed is. When choosing "off", the heater will be turned off.

- Click Input setup, choose input A, type 100 Ω Plat/500, curve 06 PT-100, Filter on, Filter points 08 and filter window 01%.
- 4. Click **Display format**, there are four locations we can set displays (two on the top and two at bottom). At **location 1**, choose **Display input A** and **Source Temp C**; at **location 2**, choose **Display input B** and **Source Temp C**; at **location 3**, choose **Display setpoint**; at **location 4**, choose **Display heater out**.
- Click Control setup, choose selected for loop 1, control with Input A, SP units Temp C, Control mode open, power up enable, setpoint Ramp on, Ramp rate 100 K/m, and heater load 50 Ω.
- 6. Click Interface, choose Baud 960, IEEE Address 12, and IEEE Term Cr Lf.
- 7. Click Zone setting, for loop 1, choose Zone 01, SP limit 0.000K, Prop (P) 50.00, Inteq (I) 20.000, Drive (D) 0.00%.
- 8. If you want to turn off the heater during the experiment, click "heater off".

APPENDIX C: SUPPLEMENTAL INFORMATION FOR THERMO-RESPONSIVE BEHAVIOR OF LINEAR COPOLYPEPTOID NANOSTRUCTURES INVESTIGATED WITH ATOMIC FORCE MICROSCOPY

1. Preparation of Nanopores within a Film of Octadecyltrichlorosilane (OTS)

Particle lithography was used to generate organosilane nanopatterns on Si(111) surfaces. The silicon substrates were cleaned by immersion in piranha solution for 1.5 h. Piranha solution, which is a mixture of sulfuric acid and hydrogen peroxide at a ratio of 3:1 (v/v), is highly corrosive and should be handled cautiously. Substrates were then rinsed copiously with deionized water and dried under argon. Monodisperse silica mesospheres (500 nm diameter) were washed with water for three times by centrifugation to remove trace charge stabilizers or surfactants. The pellet of silica mesospheres was resuspended in water by vortex mixing, and a drop (10 µL) was deposited on a clean substrate. The sample was dried in air for 2 h to produce surface masks for further chemical steps. As water evaporated during the drying step, capillary forces pull the mesospheres together to form crystalline layers on flat surface. Next, the substrate was placed in an oven at 140 C for 24 h to temporarily anneal the mesospheres to the surface. After cooling, the sample was immersed in a 0.1% solution of OTS (v/v) in toluene for 5 h. Next the sample was rinsed with water and ethanol. To remove the mesoparticles, the substrate was sonicated for 15 min in ethanol and water successively. The sample was dried under argon and characterized by atomic force microscopy (AFM) with contact-mode in ambient air (Figure C1).

The hexagonal arrangement of the nanopores can be clearly seen in the $10 \times 10 \ \mu m^2$ topography (Figure C1 a) and lateral force (Figure C1 b) images. The shapes of the nanopores are more discernible is the zoom-in view (Figure C1 c). The chemistry difference of methyl terminated silane and the bare Si substrate is distinguishable in the lateral force image (Figure C1 d). The

depth of the nanopores is ~1.6 nm measured with the cursor profile (Figure C1 e) over 2 nanopores in the zoom-in area (Figure C1 c).

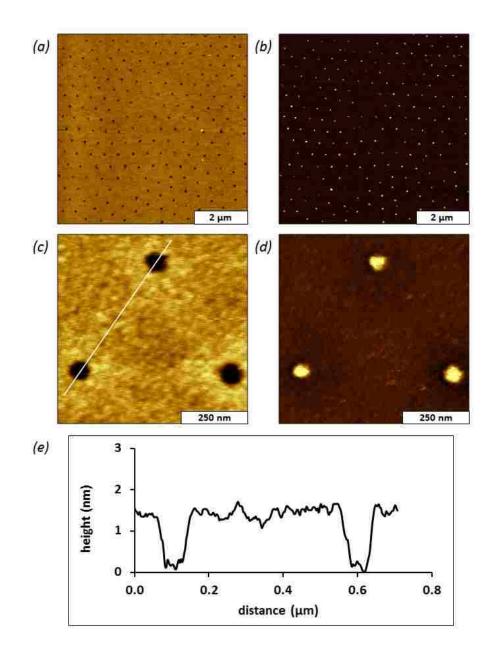


Figure C1 Nanopore patterns within a thin film of OTS acquired by contact-mode AFM. (a) $10 \ \mu m^2$ topography view. (b) Corresponding lateral force image of a. (c) Zoom-in topograph of a. (d) Simultaneously acquired lateral force image of c. (e) Height profile for the line in c.

2. Thermo-responsiveness Study of Height Changes of Two Polypeptoid Brush Sites

The height changes of polypeptoid brushes are shown in Figure 4.4 at three selected temperatures. The height tracking over two exact same sites under selected temperatures are shown in Figure C2.

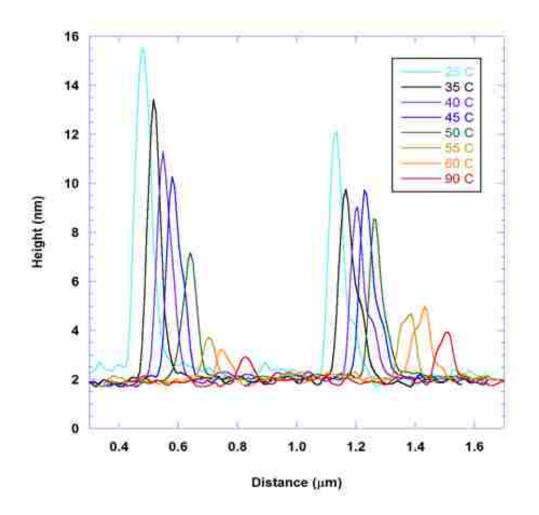


Figure C2 *In situ* temperature study of height changes of two copolypeptoid brush sites. Heights of both sites decreased from 25 C to 90 C.

3. Cloud Point Temperature (T_{cp}) Measurement with Turbidity Assay

Copolypeptoid poly[(*N*-ethyl glycine)₃₂-*r*-(*N*-butyl glycine₁₇)], or P(NEG₃₂-*r*-NBG₁₇), was dissolved in distilled water at room temperature. This aqueous solution was then transferred to a vitro-dynamic cell which was sealed at both ends. The Vitrocom cell walls were 1.0 mm in thickness. The polymer solution was then placed in a Mettler heating stage, from which the control of the temperature ramp could be accessed using controller Mettler Fp 80 central processing unit. The heating rate was 1 C/min. An Olympus optical microscope was used to collect the transmittance through the sample on the Mettler heating stage and the intensity was collected by a Mettler photomonitor. This process has been outlined in the Mettler handbook. After transmittance normalization, the onset cloud point temperature (T_{cp}) was determined to be the temperature at 90% transmittance. The measured onset T_{cp} is 45 C in our experiment (Figure C3). The transition window ΔT is 28 C (68 C – 40 C).

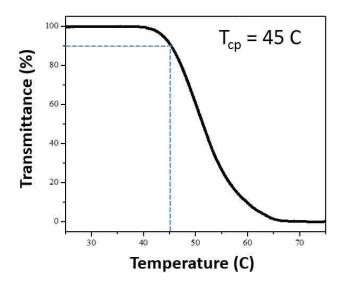


Figure C3 The LCST behavior of the copolypeptoid studied with the turbidity assay collected from the untethered copolymer in aqueous solution. The cloud point temperature (T_{cp}) measured at 50% transmittance is 51.4 C for the copolypeptoid P(NEG₃₂-*r*-NBG₁₇).

4. ¹H NMR Characterization

¹H NMR spectrum (Figure C4) was recorded on a Bruker DPX-400 spectrometer, and the chemical shifts in parts per million (ppm) were referenced relative to CD₂Cl₂.

The molar percents of the *N*-ethyl glycine and *N*-butyl glycine were confirmed via the comparative integration of the methyl peak from PNEG (1.2 ppm) and PNBG (0.9 ppm) to the benzyl peaks from the initiator (7.0 ppm).

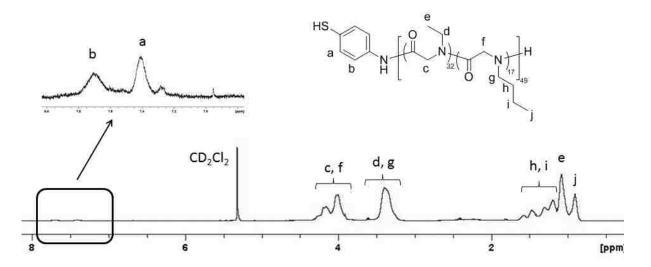


Figure C4 The 400MHz ¹H NMR spectrum of copolypeptoid P(NEG₃₂-*r*-NBG₁₇) in CD₂Cl₂.

5. Size Exclusive Chromatography (SEC)

An Agilent 1200 SEC was used to acquire the polymer molecular weight (Mw) and polydispersity index (PDI). A solution of DMF containing 0.1 M LiBr was used as the eluent at a flow rate of 0.5 mL· min⁻¹. All data analyses were performed using Wyatt Astra v5.3 software. The Mw is 14.5 kDa and the PDI is 1.24 by using polystyrene standards (molecular weight Mn = $590 \text{ g} \cdot \text{mol}^{-1} - 1472 \text{ kg} \cdot \text{mol}^{-1}$, Polymer Laboratories, Inc.)

APPENDIX D: SUPPLEMENTAL INFORMATION FOR SAMPLE STAGE DESIGNED FOR FORCE MODULATION MICROSCOPY USING A TIP-MOUNTED AFM SCANNER

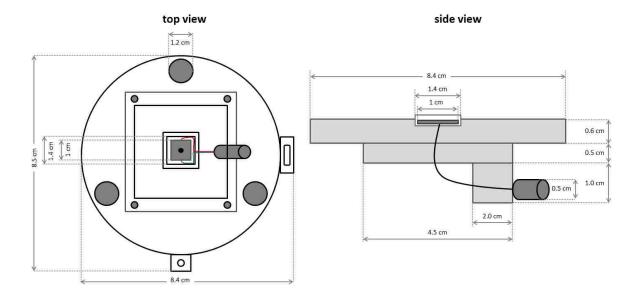


Figure D1 Physical dimensions of the force modulation sample stage. At the center of the stage, a square $(1 \times 1 \text{ cm}^2)$ piezoactuator is located underneath a polycarbonate plate $(1.4 \times 1.4 \text{ cm}^2)$. There is a small air gap surrounding and between the polycarbonate pieces and the sample stage so that only the central area is driven to vibrate.



Figure D2 Steps for making nanopores within a thin film of OTS prepared by particle lithography combined with solution immersion.²⁴³ A drop of an aqueous suspension of silica mesospheres in water (10 μ L) was deposited on a clean Si(111) substrate. The sample was dried in air for 2 h to produce surface masks. As water evaporated during the drying step, capillary forces pull the mesospheres together to form crystalline layers on flat surfaces. The substrate was placed in an oven at 140 C overnight to temporarily anneal the mesospheres to the surface. After cooling, the sample was immersed in a 0.1% solution (v/v) of OTS in toluene for 5 h to form an OTS film surrounding the surface mask. To remove the mesoparticles, the substrate was sonicated for 15 min in ethanol and water successively. The sample was dried under argon before characterization with FMM-AFM.

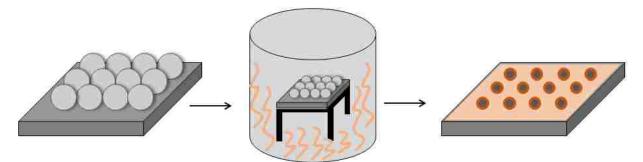


Figure D3 Basic steps to prepare nanorings of PEG-silane using particle lithography combined with heated vapor deposition.²⁴² A drop of a suspension of 500 nm latex mesospheres (10 μ L) in water was deposited on a clean Si(111) substrate. The sample was dried in air for 5 h to produce surface masks. Next, the sample was placed in a vessel containing 300 μ L neat PEG-silane. The sealed container was placed in an oven (70 C) overnight. Vapor-phase PEG-silane will attach to the Si substrate except in places where the mesosphere mask has protected the substrate. After cooling, the sample was rinsed with water and ethanol. To remove the mesoparticles, the substrate was sonicated for 15 min in ethanol, toluene, and water successively. The sample was dried under argon before characterization with FMM-AFM.

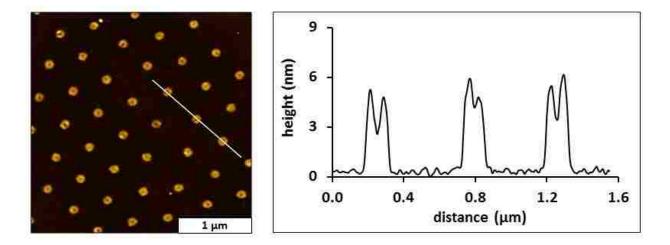


Figure D4 Height measurements of nanorings of PEG-silane. (Left) View of PEG-silane nanorings revealed with a topography frame; (Right) Height profile for the white line drawn across three nanorings.

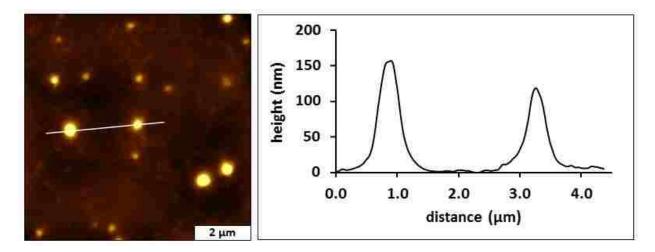


Figure D5 Example height measurements of selected aggregates of the polymer gel. (Left) View of the polymer gel sample disclosed with a topography frame; (Right) Height profile for the white line drawn across an area of the nanoclusters.

APPENDIX E: SUPPLEMENTAL INFORMATION FOR DIRECT COMPARISON OF SAMPLE ACTUATION VERSUS TIP VIBRATION CONFIGURATION FOR FORCE MODULATION AFM

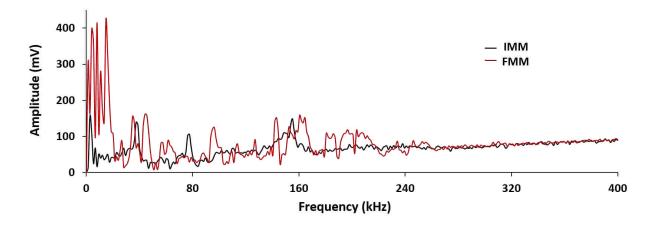


Figure E1 Overlay of the Frequency sweeps of FMM and IMM.

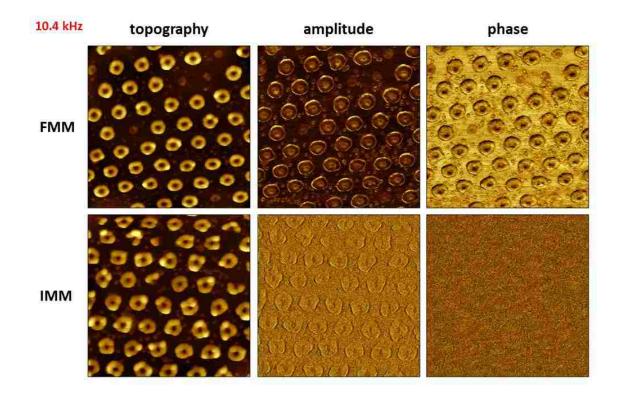


Figure E2 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 10.4 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

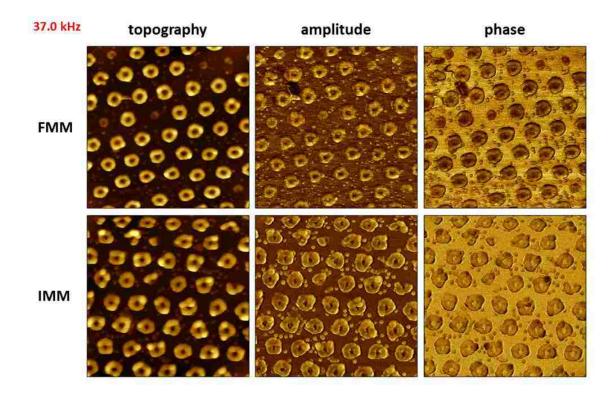


Figure E3 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 37.0 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

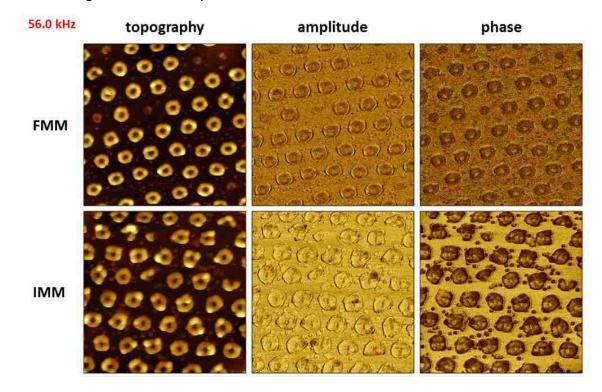


Figure E4 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 56.0 kHz. Image sizes are 3 \times 3 μm^2 .

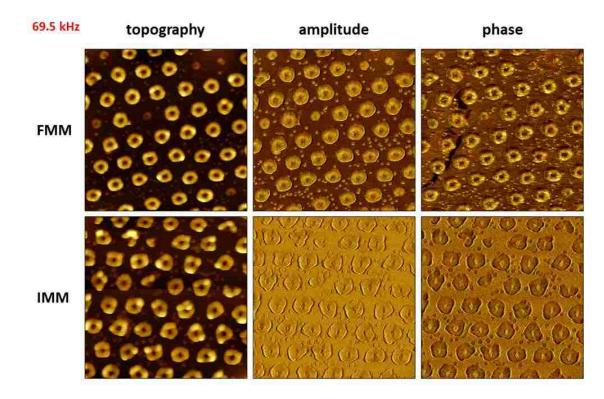


Figure E5 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 69.5 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

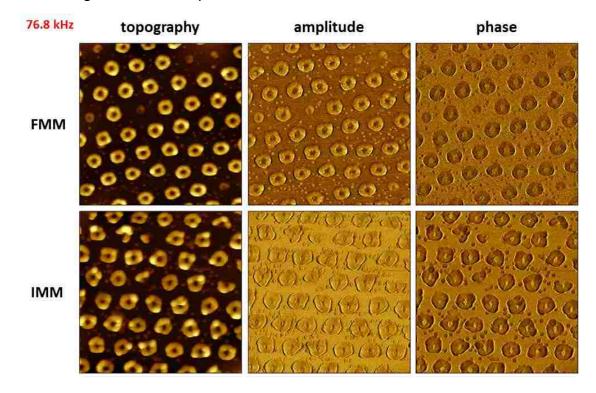


Figure E6 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 76.8 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

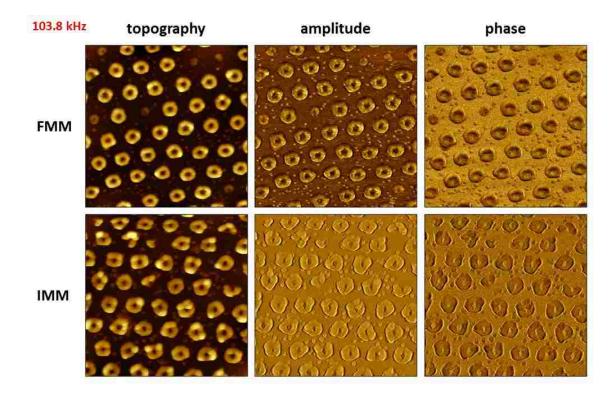


Figure E7 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 103.8 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

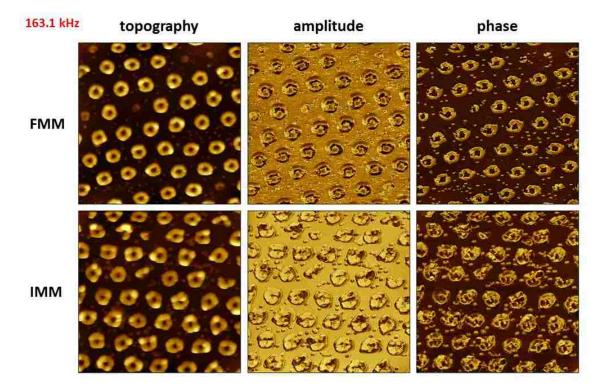


Figure E8 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 163.1 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

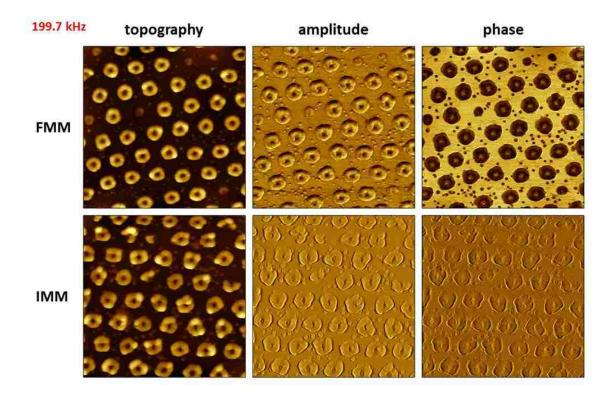


Figure E9 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 199.7 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

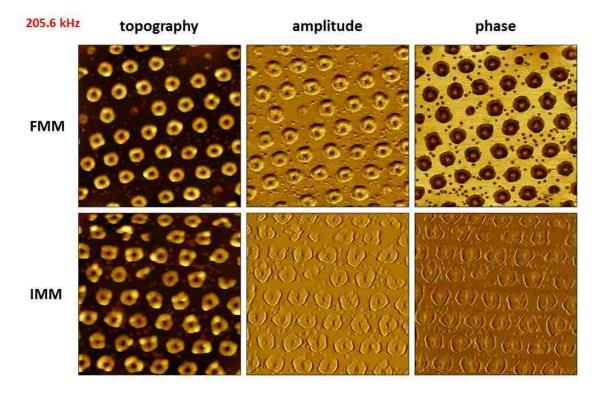


Figure E10 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 205.6 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

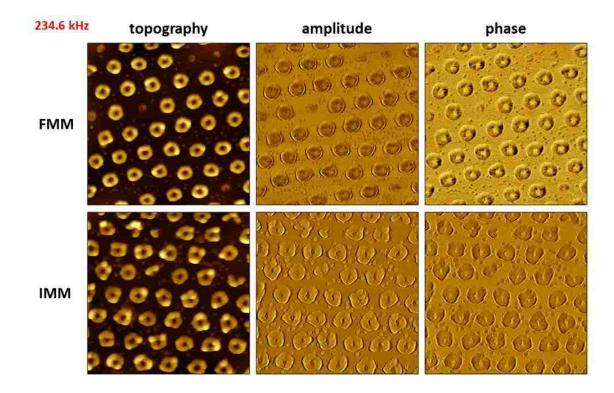


Figure E11 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 76.8 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

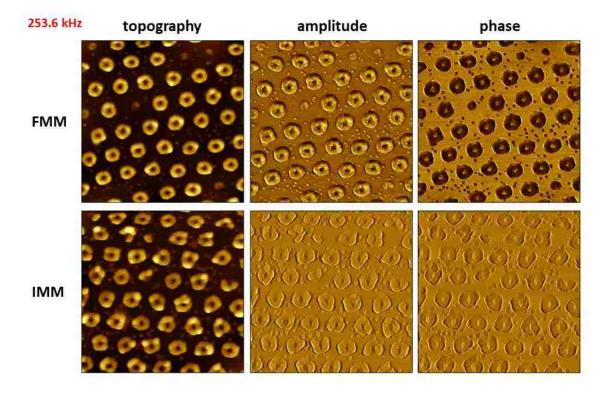


Figure E12 Comparison of stage-driven FMM and tip-driven IMM of CMPS nanorings at frequency 253.6 kHz. Image sizes are $3 \times 3 \ \mu m^2$.

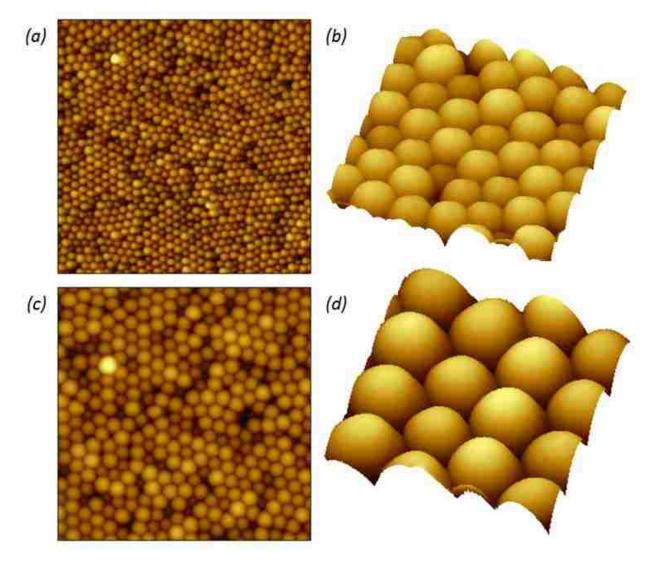


Figure F1 The surface organization of polystyrene latex mesospheres on mica(0001) imaged with tapping mode AFM. (a) Topography view of 300 nm latex, $10 \times 10 \mu m^2$; (b) topography view of 300 nm latex, $2 \times 2 \mu m^2$; (c) topograph of 300 nm latex, $6 \times 6 \mu m^2$; (d) view of 500 nm latex, $2 \times 2 \mu m^2$.

APPENDIX F: PERMISSIONS



Imaging of Dynamic Viscoelastic Properties of a Phase-Separated Polymer Surface by Forced Oscillation Atomic Force Microscopy Author: Tisato Kajiyama, Keiji Tanaka, Isao Ohki, et al Publication: Macromolecules Publisher: American Chemical Society Dec 1, 1994



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VITA

Lu Lu was born and grew up in Lanzhou, China. She earned her Bachelor of Science degree in polymer science and engineering department from University of Science and Technology (USTC) of China in 2010. During her time in USTC, she participated in undergraduate research under Dr. Ruke Bai for a year and published a co-authored journal article. She joined Chemistry department at Louisiana State University (LSU) in the Fall of 2010. She is a Ph.D candidate in the fields of analytical and macromolecular chemistry under the supervision of Dr. Jayne C. Garno and Dr. Donghui Zhang. Her research interests include: preparing patterns of polymer brushes on surfaces, studying the thermo-responsive properties of patterned polymer nanobrushes using atomic force microscopy (AFM) and developing sample stage accessories with AFM for force modulation microscopy studies. Thus far at LSU, Lu submitted one first author journal articles and published five collaborative research papers. She had four more first author and several shared manuscripts which are under preparation. Lu presented her research at both regional and national conferences including one talk, five first-author posters and four co-authored posters. Lu also gave a talk in the workshop held by Keysight Technologies at LSU. Lu directed senior thesis research for an undergraduate student at LSU, whose name is Rasheda Gros. Rasheda won a poster award in 2014 Annual Biomedical Research Conference for Minority Students (ABRCMS) for her studies with AFM investigations of nanopatterns prepared with organosilane and nanoparticles.